

Status of GEM gating studies

~ Electron transmission measurement ~

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LCTPC-Asia Face-to-Face Meeting (1 June, 2014)

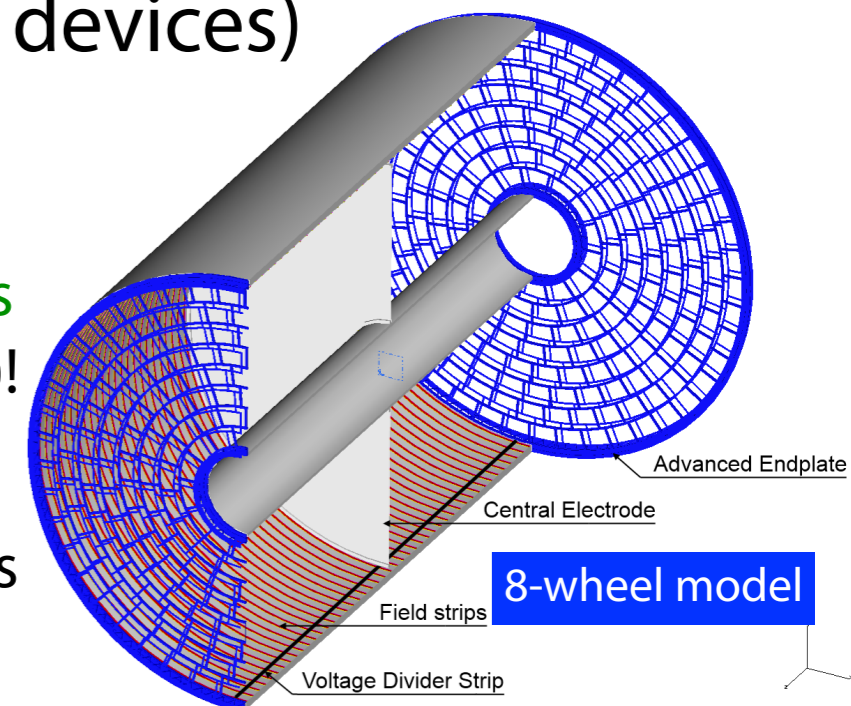
Introduction

● TPC for ILD

- The ILD concept for ILC: have a **GEM- or Micromegas-based TPC** as a main tracker
 - ▶ use of **Micropattern gaseous detectors (MPGD)** to replace the **MWPCs** (not possible to reach the required spatial resolution with a wire-based readout because the strong magnetic field of $B = 3.5$ T and the wide gap of 1-2 mm between wires leads to **strong $E \times B$ -effects**)
- **Another advantage of MPGDs**: a large fraction of positive ions created in the gas amplification are guided to an electrode and are neutralized there
 - ▶ the number of ions potentially reaching the drift volume is greatly reduced (**Ion feedback suppression**)
 - ▶ do we really need a gating device located between the drift volume and the gas amplification device to prevent positive ions from entering the drift region?? => **next slide**

● Features of ILD-TPC (for a discussion of gating devices)

- Point resolution of better than **$100 \mu\text{m}$** for long drift (~ 2.3 m)
=> need a gas mixture in which **$D(B = 0)$** is small (cool) and **τ** (mean free time of drift electrons between collisions with gas molecules) is fairly large (fast) under a moderate drift field (E)!
 - ▶ use of $\text{Ar}:\text{CF}_4:\text{iC}_4\text{H}_{10}$ (95:3:2), so called **T2K gas**
- **Modular endplate detectors**: concentric assembly of modules (current design: 240 modules of approximately $17 \times 22 \text{ cm}^2$)



Positive ion feedback in ILD-TPC

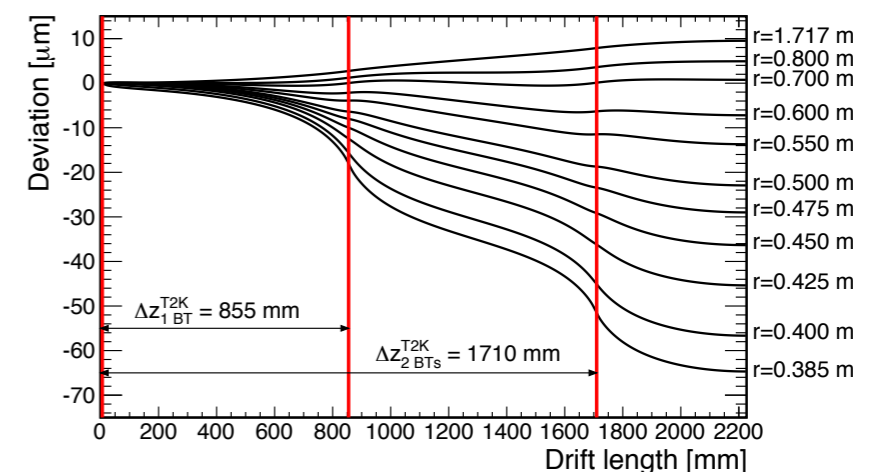
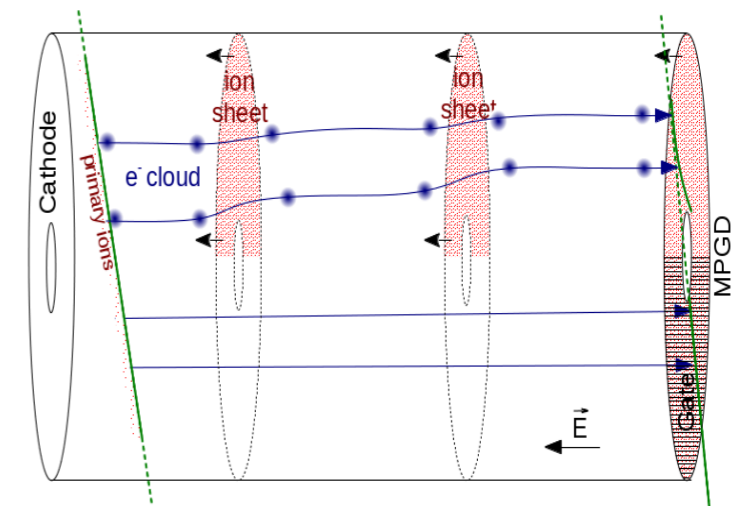
High performance of tracking by the TPC relies strongly on the quality of the electric field in the drift volume!

- **Positive ions drifting back into the gas volume**

- **Well known issue** for wire chambers based TPCs (traditional MWPCs)
- Even though the amount of back drift ions is much smaller for MPGD amplification, still be **significant with a high track density like ILC background conditions** (e.g. ILC beam expected to produce large amount of beamstrahlung = e^+e^- pair background)

- **In the case of ILD-TPC**

- Bunch-train structure of the ILC beam (**one 1 ms train every 200 ms**) => Ions from the amplification will be **concentrated in discs of about 1 cm thickness near the readout**, and then drift back into the drift volume
- **Three such discs** in the chamber
- Simulations: a **gating system is required** to reach the tight momentum resolution requirements in the nominal running conditions of ILC
 - ▶ The ions have to be neutralised during the 200 ms period between the crossings



Conventional wire-grid as a gating device

- Wire gating grid is an option

- Traditional gating system

- Conventional transverse wires would require a structure creating dead angular regions => would put the wires radially

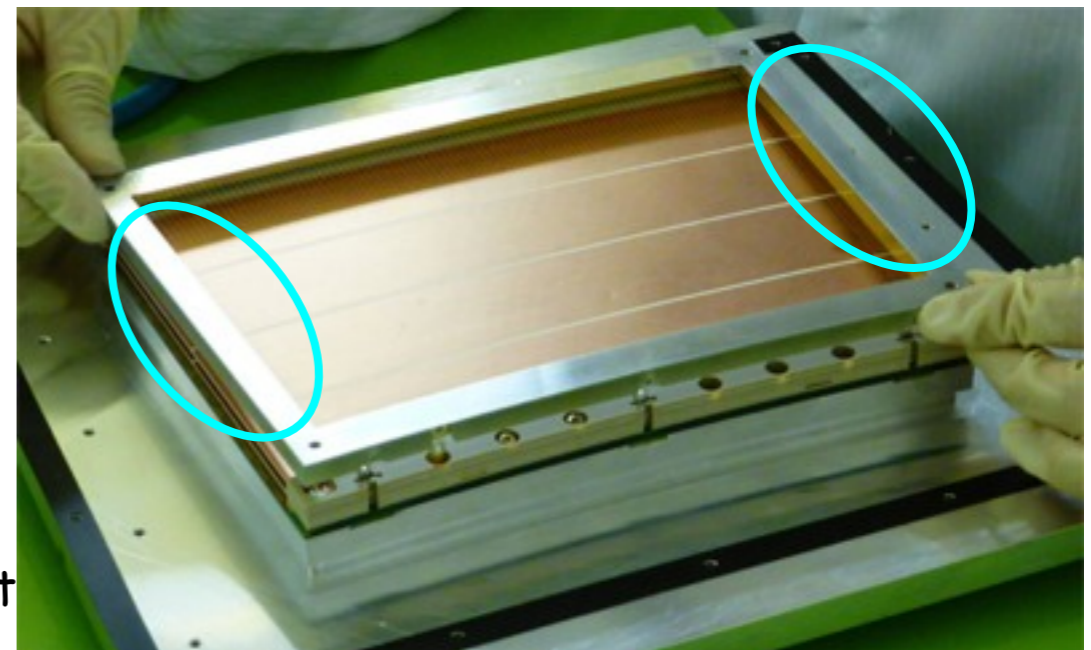
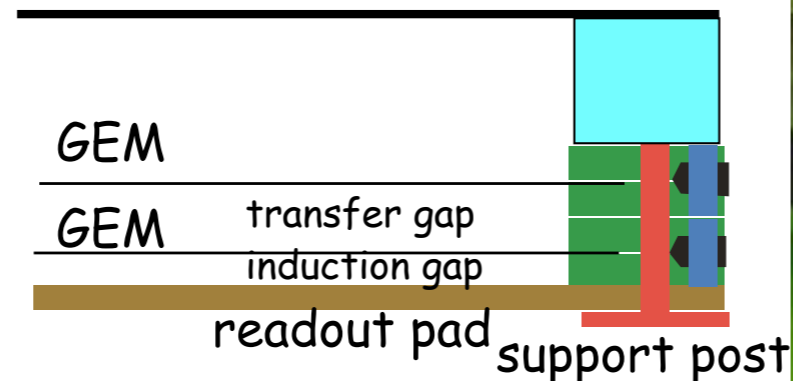
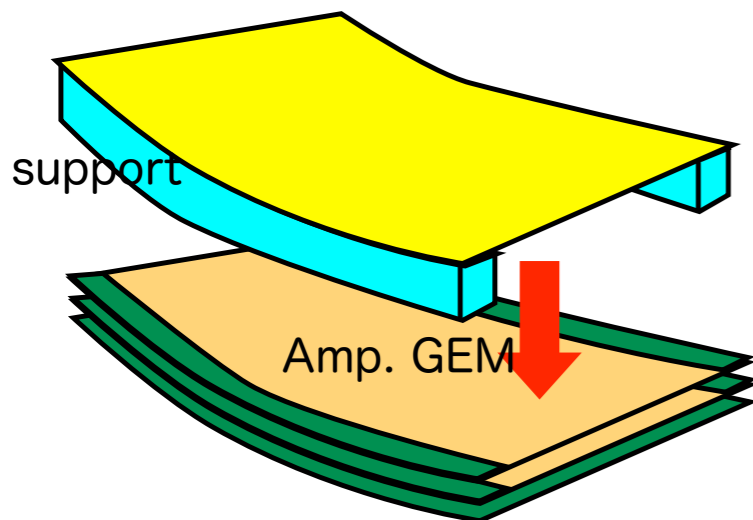
- Wires can create field distortions, and in particular ExB effects...

- **Our 1st prototype:**

- ▶ 30µm wires, 2mm pitch, radial => spot welded on stainless steel frame => **frame still too big!!**

- ▶ to be tested with UV-laser tracks in the beginning of June by Saga-Hiroshima team

- Its implementation above the amplification GEMs or Micromegas would **not be elegant!**



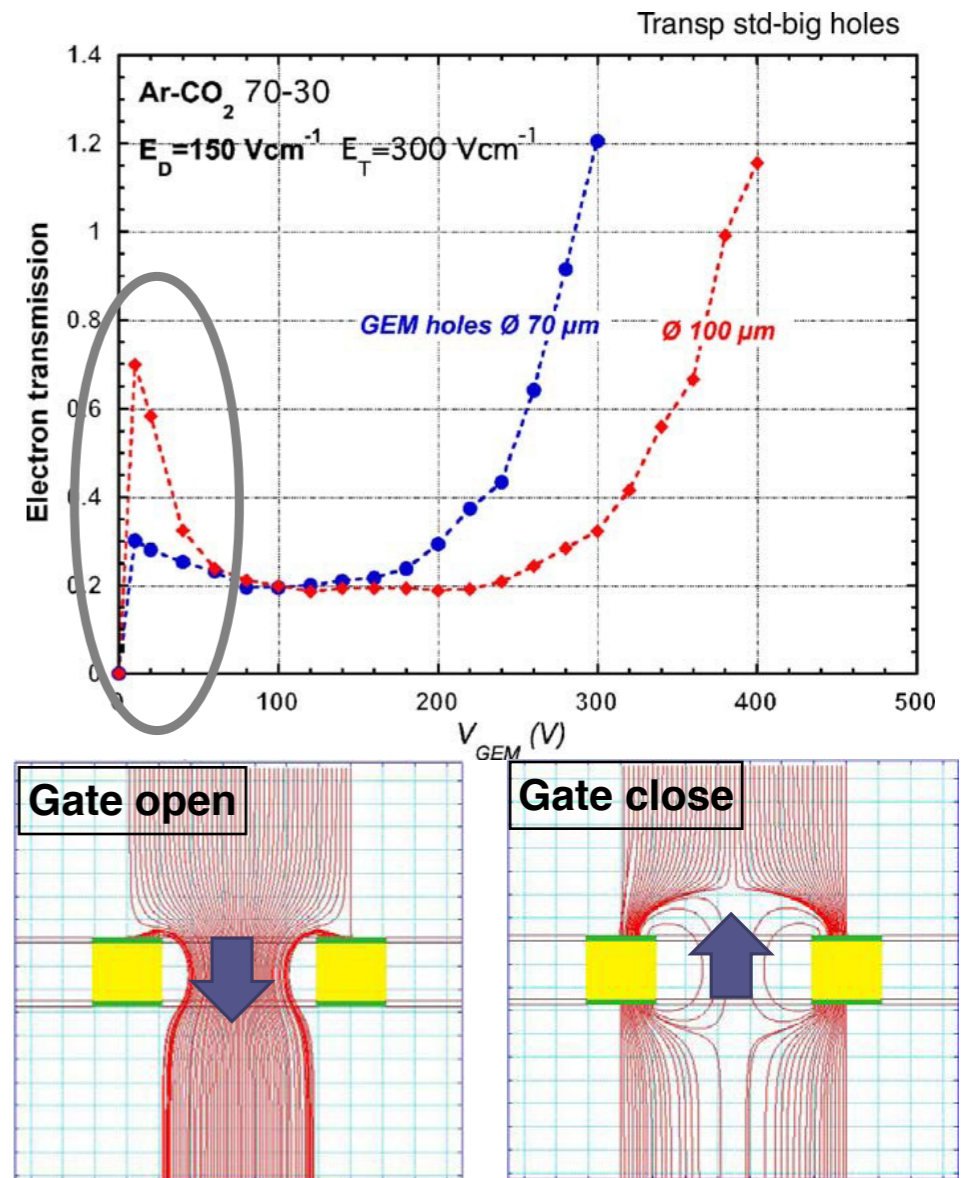
GEM as a gating device

- **GEM operated in low voltage mode**

- **Electron transmission film** = without a function of gas amplification
- **Gate having a GEM-like structure** (initially proposed by F. Sauli in 2006)
 - ▶ Gate-GEM can easily be used as a closed gate by reversing the electric field in GEM hole
 - ▶ can be achieved by changing only the potential of lower electrode of GEM, without affecting the field in drift region
- **GEM-gating device would be most adapted for the module structure of ILD-TPC!!**

- **Requirement for Gate GEMs of ILD-TPC**

- ILD-TPC: operated in a **3.5 T axial magnetic field**, and in a **gas with a high mean free time (τ)** of drift electrons between collisions with gas molecules
- **Motion of electrons is strongly restricted to the direction of the magnetic field => high optical transparency of the gate is required** to ensure its **high transmission rate of the electrons** in the open state
 - ▶ ordinary amplifying GEMs (e.g. CERN standard): not suitable because of their poor optical transparency!



Large-aperture Gate-GEM samples

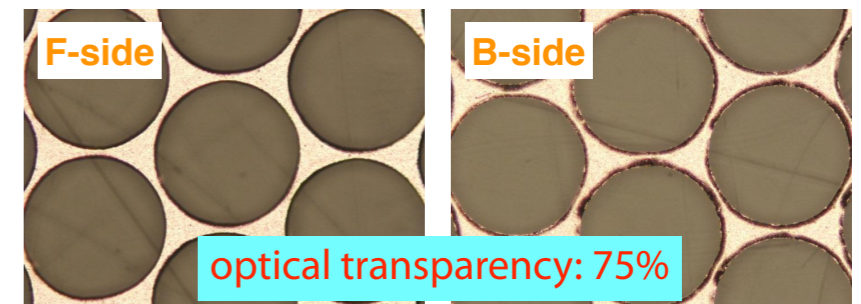
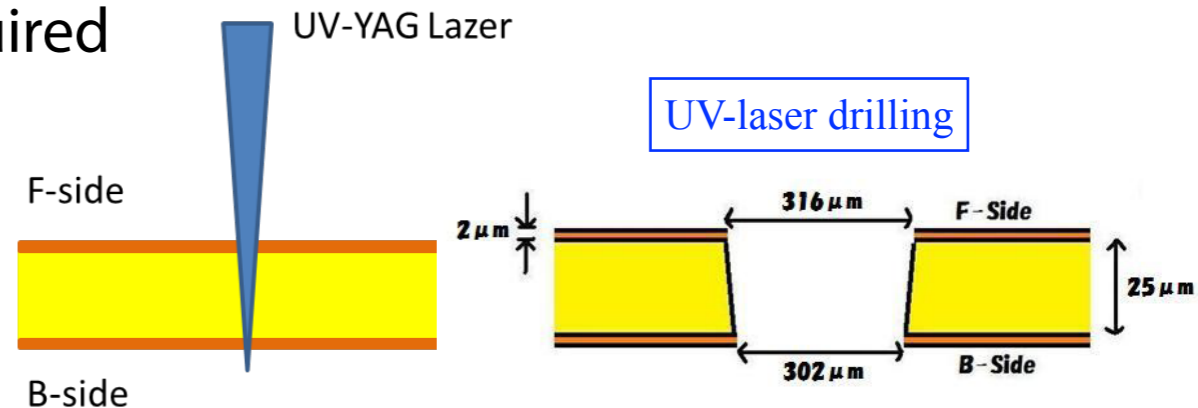
- **High optical transparency = Minimize rim width of GEM holes**
 - To achieve high electron transmission: **30 μm rim width & 330 μm pitch in honeycomb structure** (= 85~90% optical transparency) required

- **R&D by D. Arai (Fujikura Ltd.)**

- Thanks for his tremendous efforts!!!

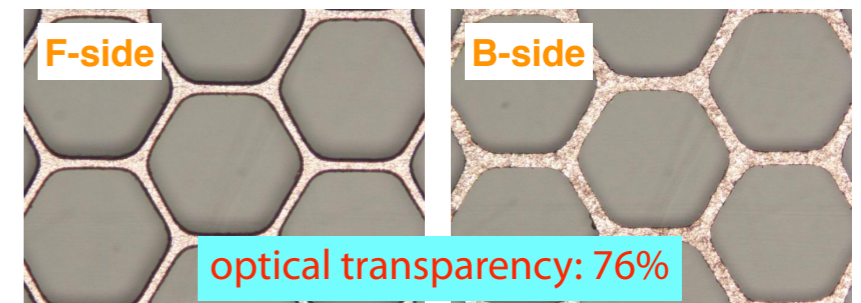
- **Fujikura Gate-GEM Type 0 sample**

- **Round holes** / UV- laser ablation technology (1 cm x 1 cm)
 - 15 μm (F-side) - 30 μm (B-side) rim width with PI thickness 25 μm : **hard enough!**



- **Fujikura Gate-GEM Type 2 sample**

- **Hexagonal holes** / Ni-plating process (9 cm x 9 cm)
 - 30(F) - 40(B) μm rim width & 300 μm pitch with PI thickness 12.5 μm



These 2 samples: tested with a test chamber installed in a 1 Tesla solenoid magnet at KEK cryo center

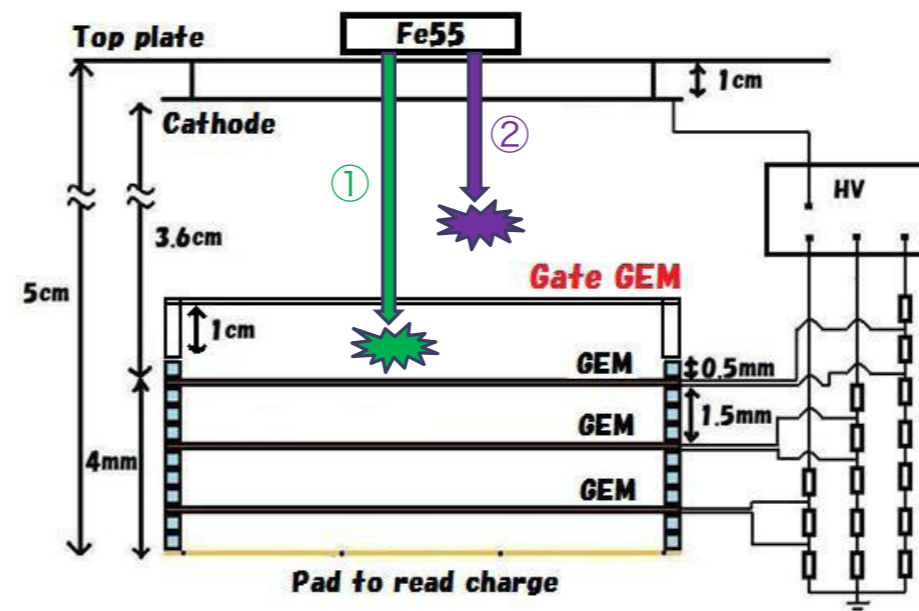
- **Fujikura Gate-GEM Type 4 sample** (Ni-less process & 20(F) μm rim width) and **RAYTECH samples** (by using precise chemical etching technique) will be tested from 7 July at KEK cryo center

Electron transmission measurement

Motion of electrons is strongly restricted to the direction of the magnetic field => need measurements under high magnetic field!

● Measurement method

- by comparing **signal charge passing through the Gate-GEM** to **signal without Gate-GEM** using a small test chamber irradiated with an ^{55}Fe source, which is installed in a 1 T MRI type super-conducting solenoid at KEK cryo center

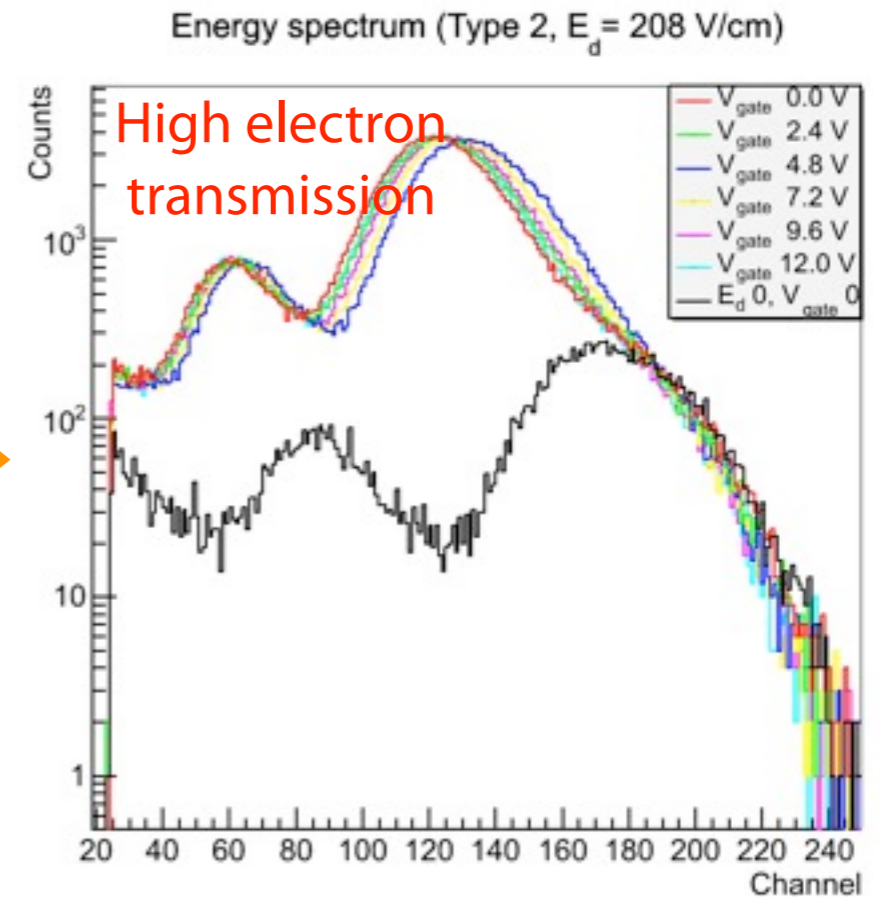
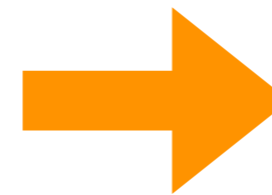
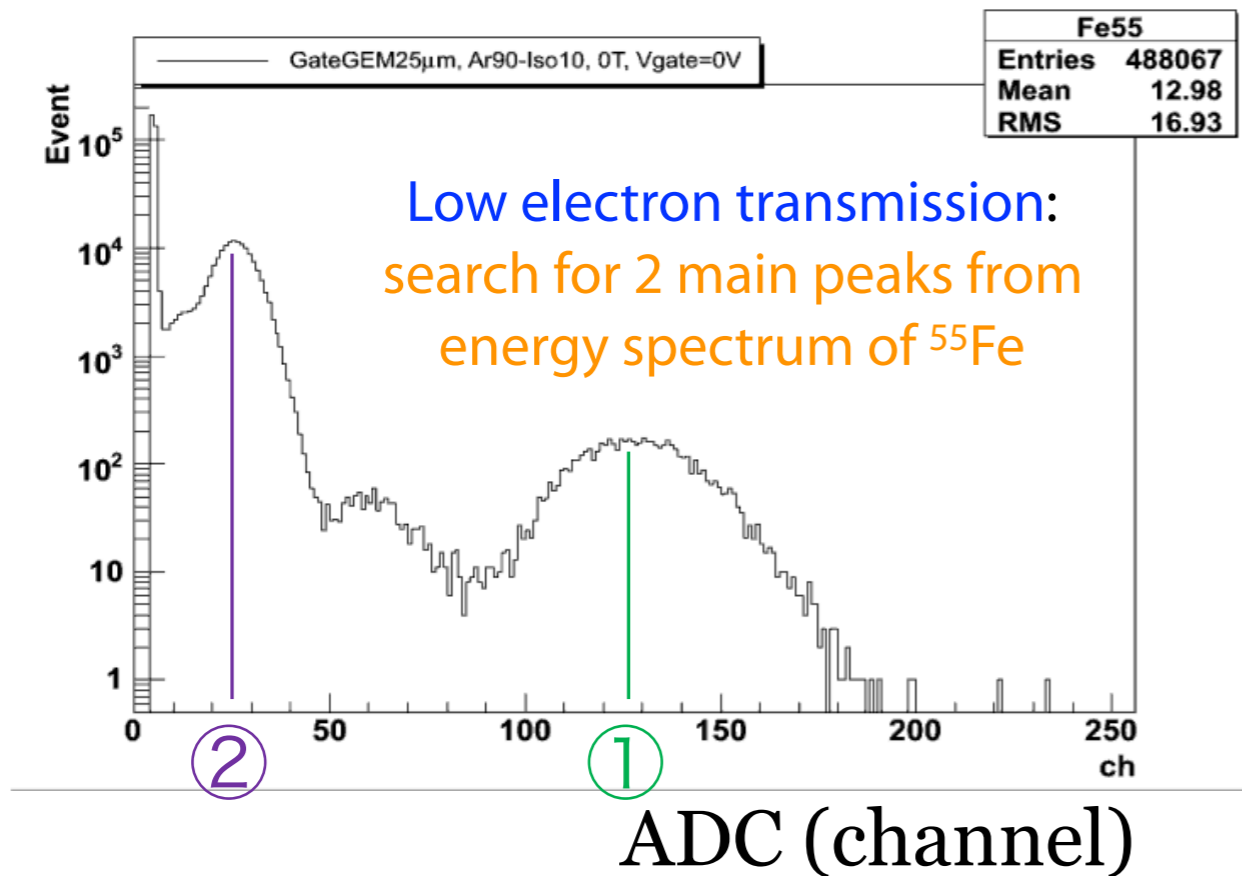


using a Fujikura 50 μm GEM readout (triple GEM stack) and one of Fujikura Gate-GEM samples placed 10 mm above

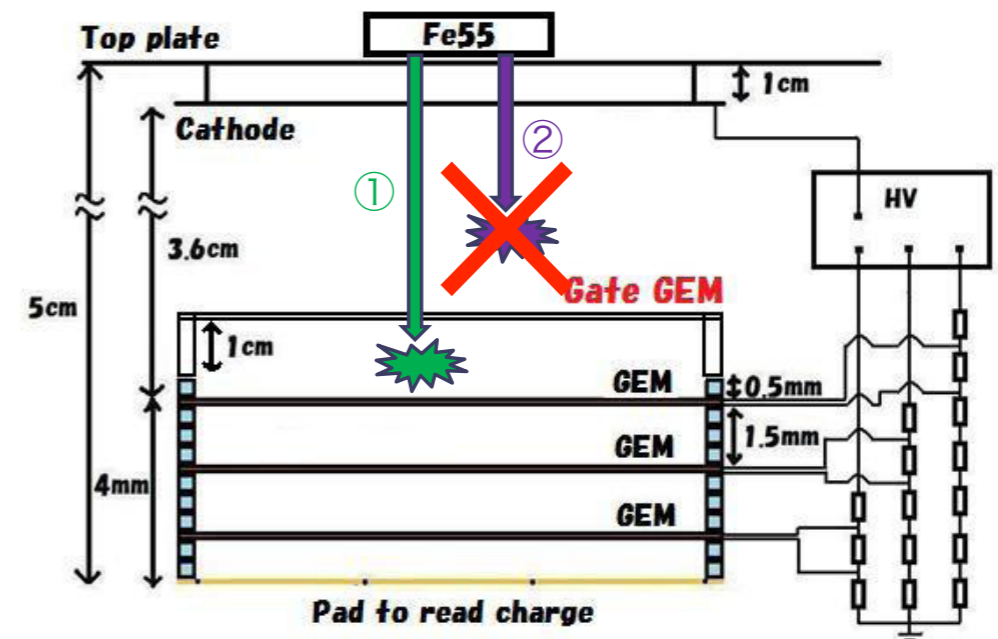
- **Case (2)**: the conversion happens in the drift region, so that the produced electrons have to pass the gate and the **signal is affected by the gate transmission**
- **Case (1)**: a small portion of the X-rays are converted in the region **between the gate and the amplification GEM**, which produces **signal without any effect of the gate**
- **Electron transmission**: calculated as the **ratio of the two signals** in the same measurement (any systematics can be cancelled out in this method)

Electron transmission measurement (cont'd)

- In the case of large-aperture Gate-GEM samples

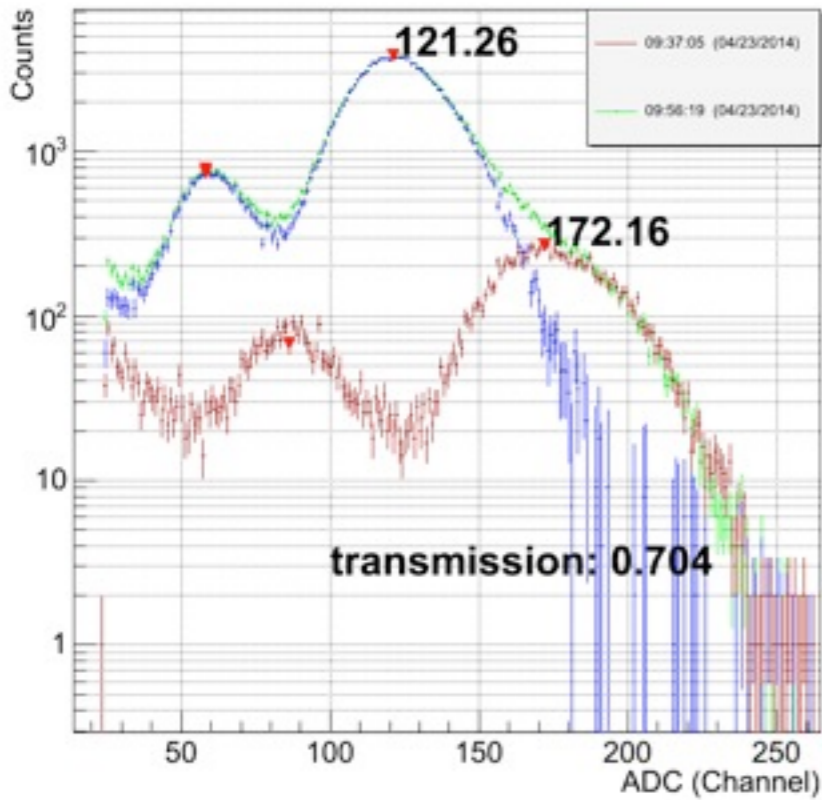


- Impossible to determine the two signals in the same measurement...
- Need to define 100% electron transmission from $E_{\text{drift}} = 0$ run
- Analysis: pick up proper $E_{\text{drift}} = 0$ run and apply corrections (e.g. correlation between gas gain and T/p)

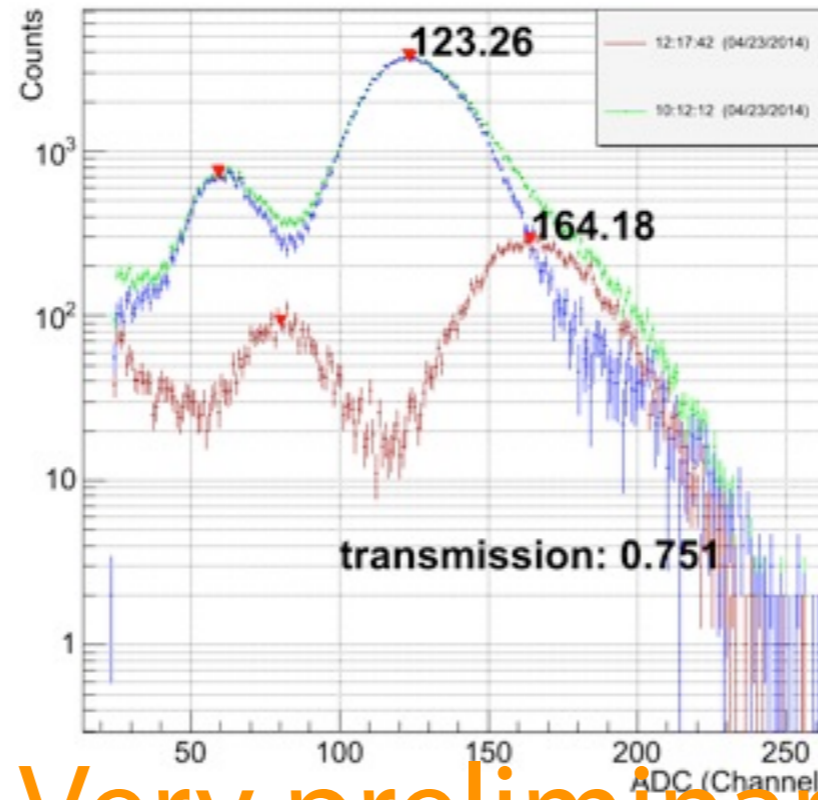


Type 2, T2K gas, $B = 1$, $E_d = 208$ V/cm

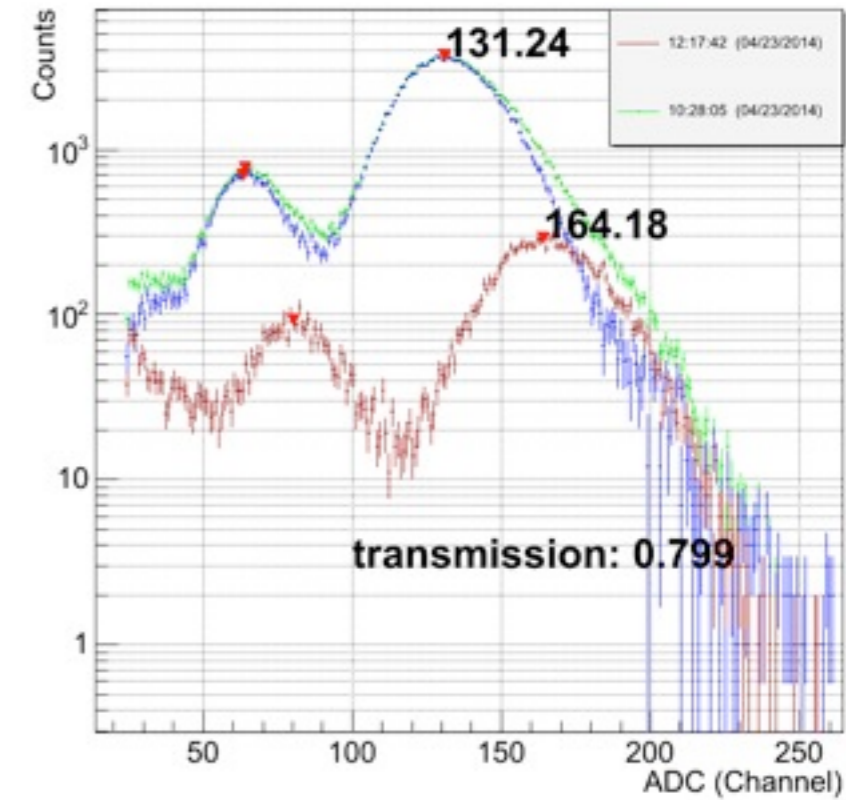
FType2, T2K, $E_d = 208$ [V/cm], $V_{gate} = 0.0$ [V], $B = 1$ [T]



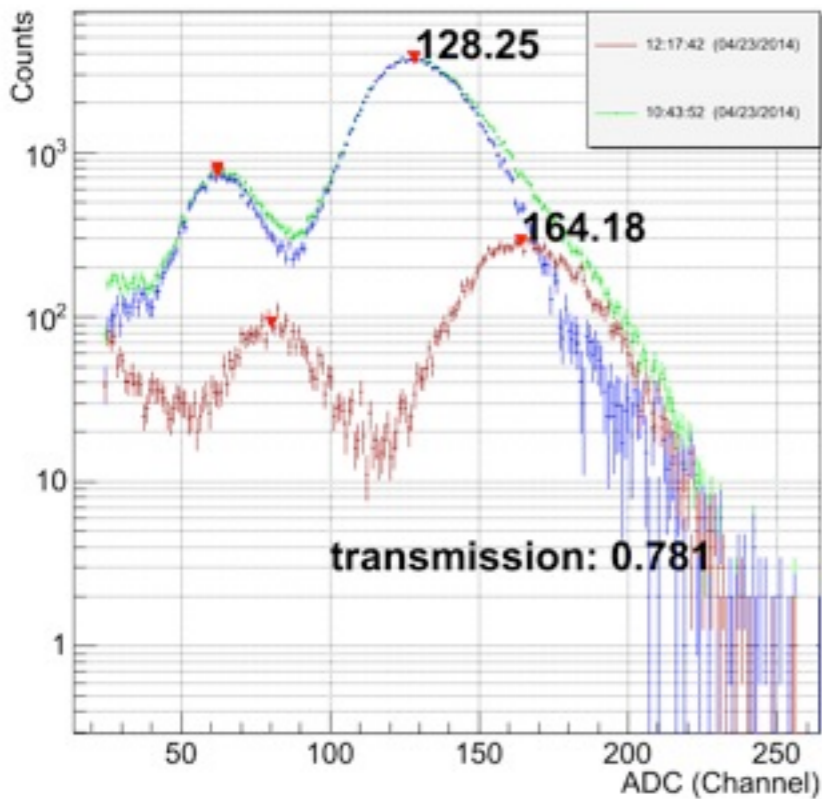
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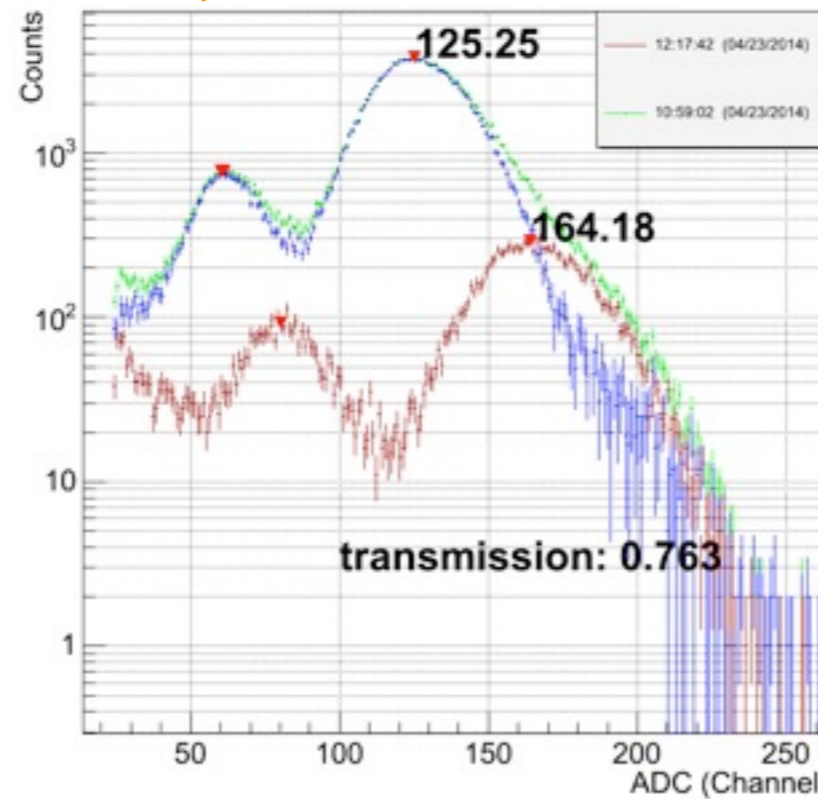
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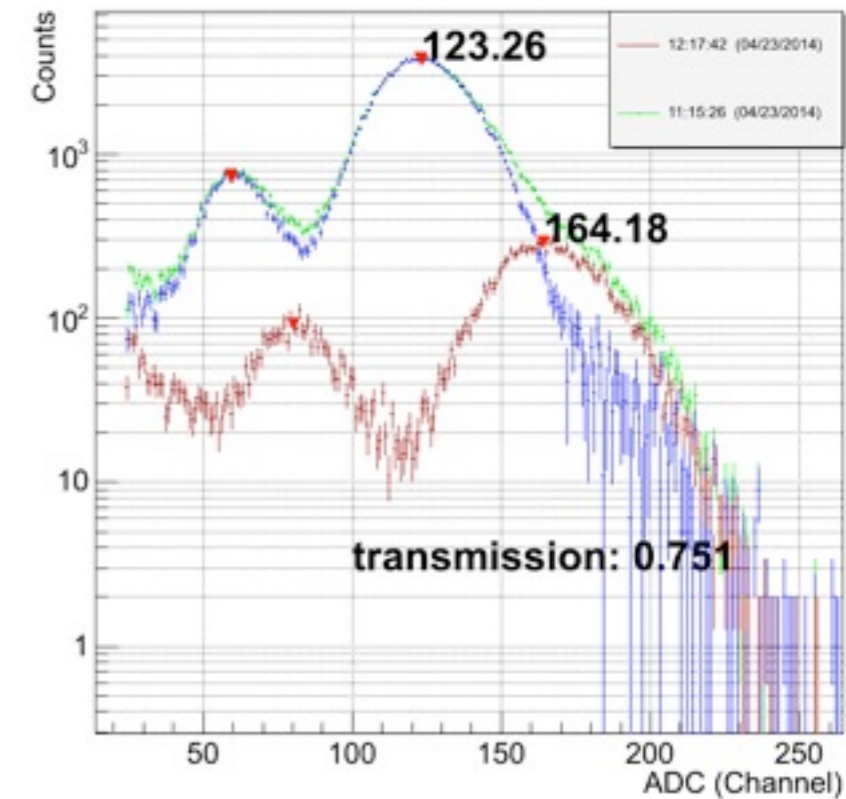
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FType2, T2K, $E_d = 208$ [V/cm], $V_{gate} = 9.6$ [V], $B = 1$ [T]



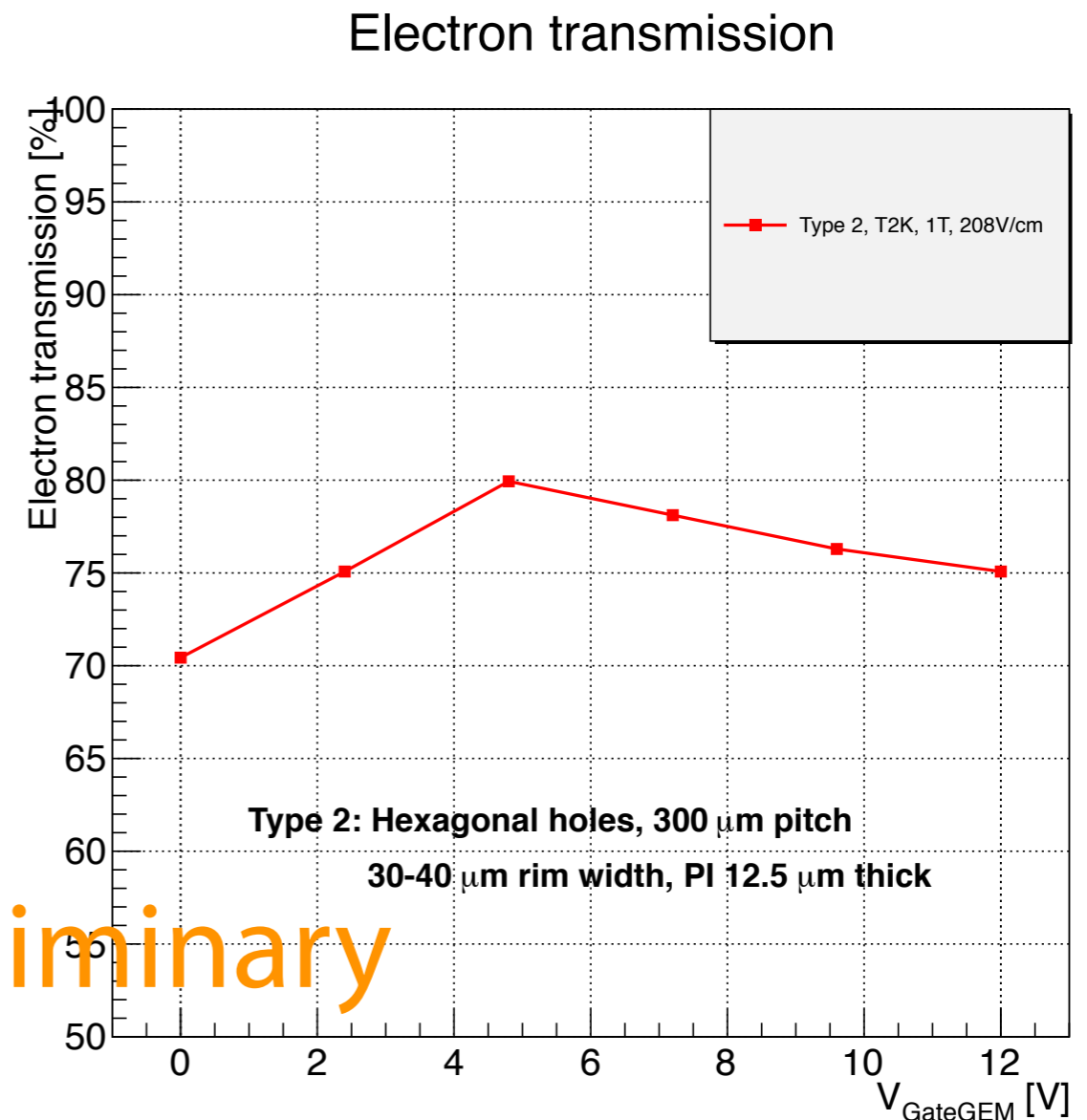
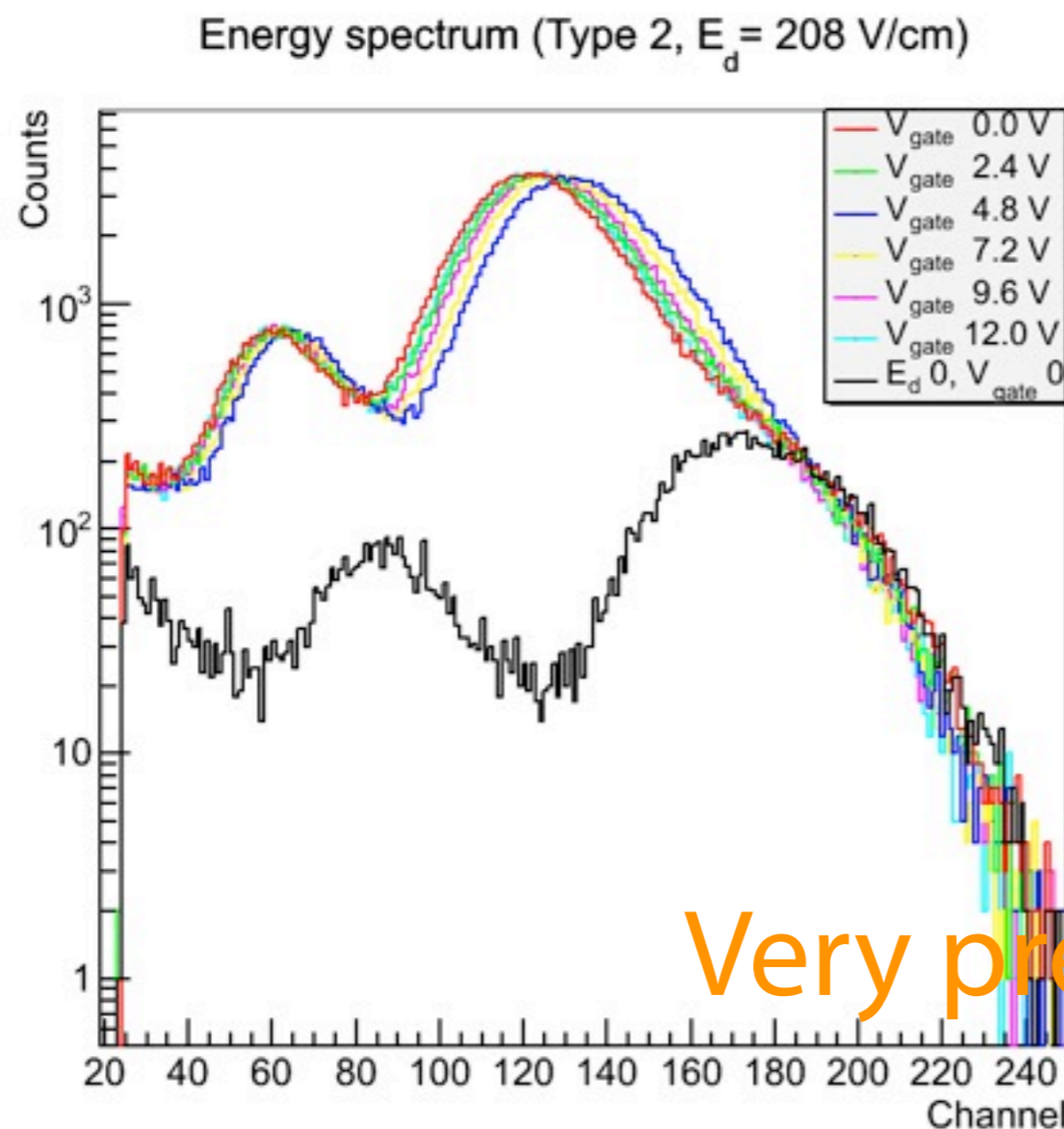
FType2, T2K, $E_d = 208$ [V/cm], $V_{gate} = 12.0$ [V], $B = 1$ [T]



Very preliminary

Type 2, T2K gas, $B = 1$, $E_d = 208 \text{ V/cm}$

Measured energy spectrum, and electron transmission as a function of the voltage applied to gate GEM



Very preliminary

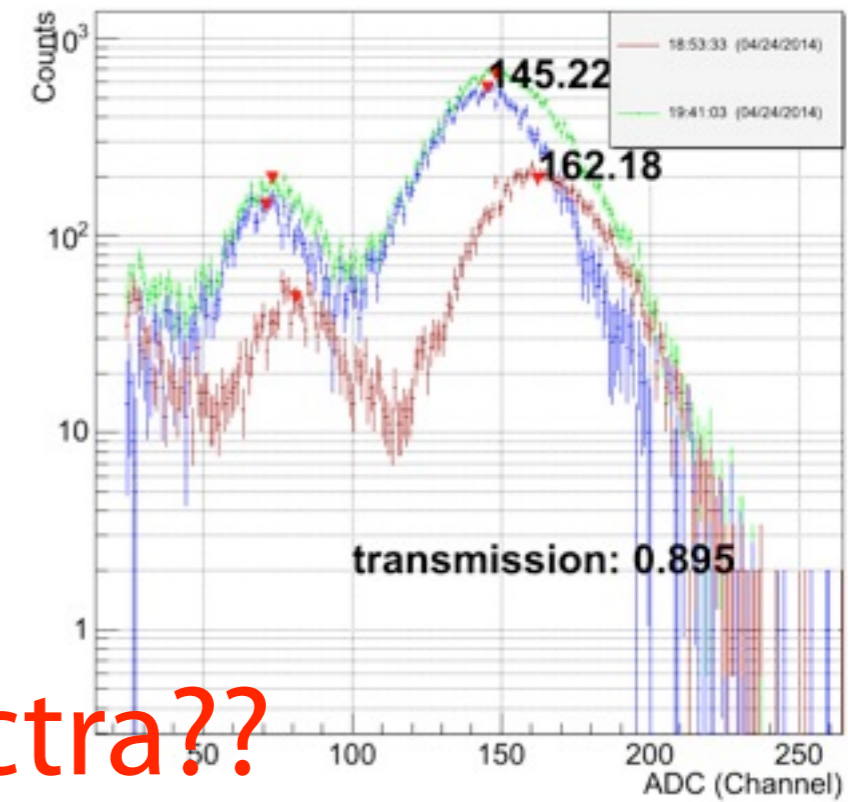
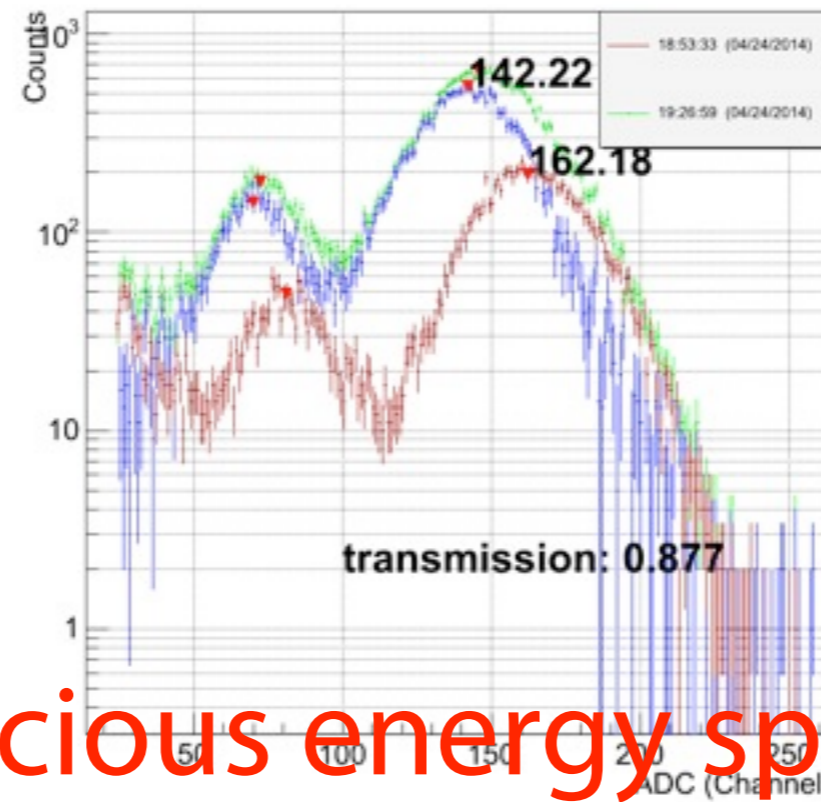
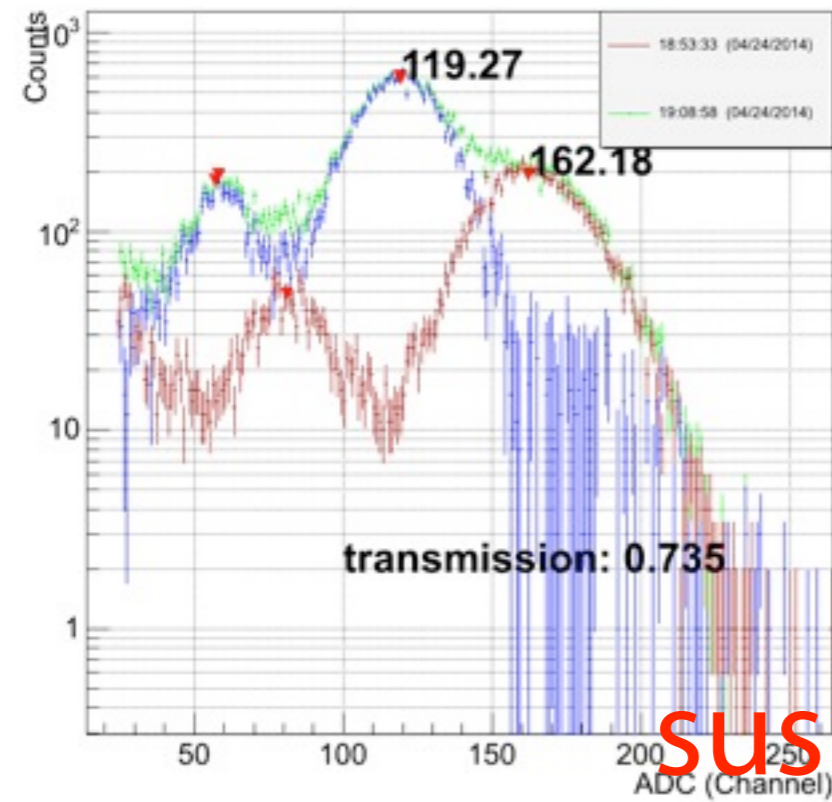
- Electron transmission of Fujikura Type 2 sample: reached about 70-80% under 1 T
- Need comparison with simulation (ANSYS/Garfield++ framework)

Type 0, T2K gas, $B = 1$, $E_d = 208$ V/cm

FType0, T2K, $E_d = 208$ [V/cm], $V_{gate} = 0.0$ [V], $B = 1$ [T]

FType0, T2K, $E_d = 208$ [V/cm], $V_{gate} = 2.4$ [V], $B = 1$ [T]

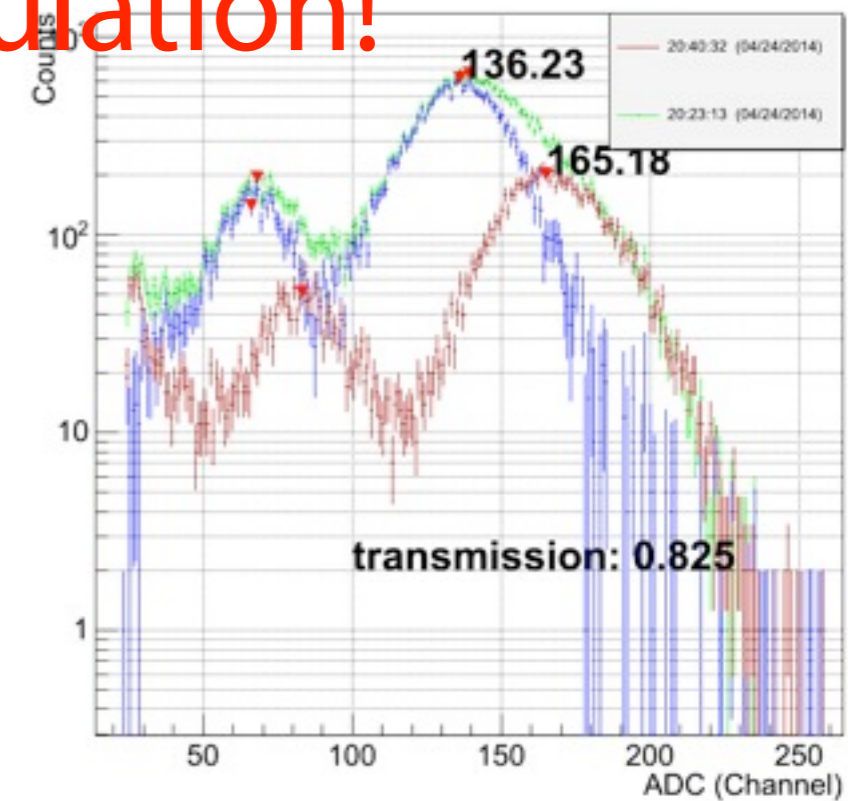
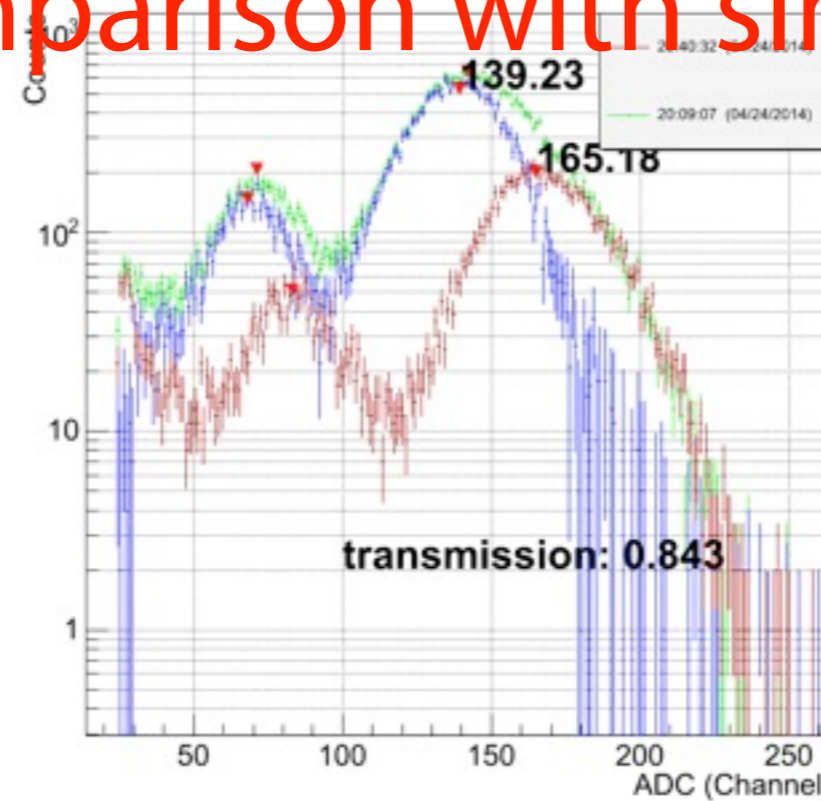
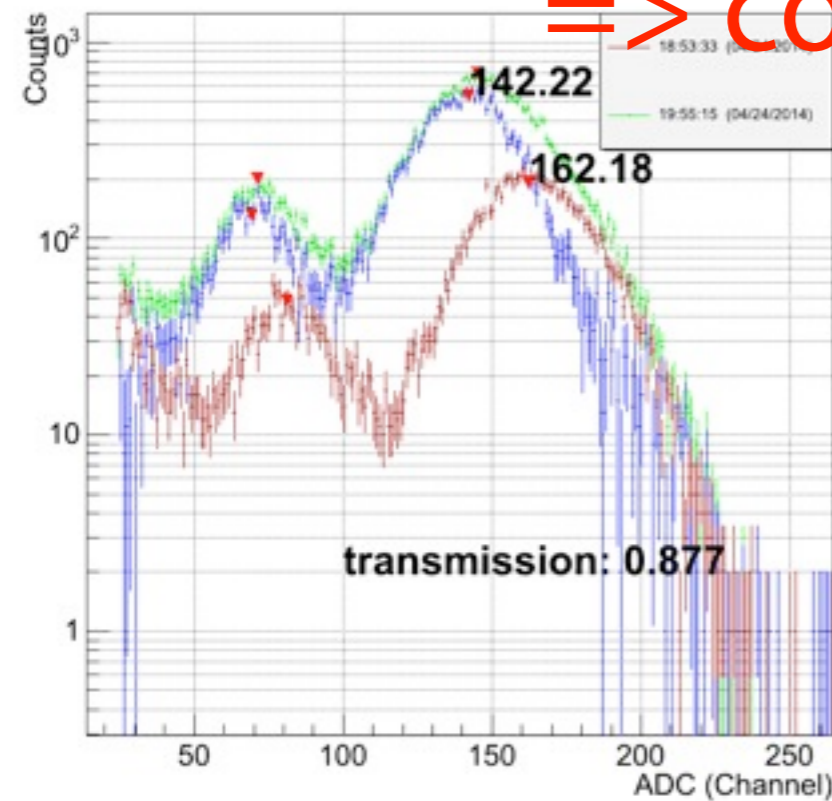
FType0, T2K, $E_d = 208$ [V/cm], $V_{gate} = 4.8$ [V], $B = 1$ [T]



FType0, T2K, $E_d = 208$ [V/cm], $V_{gate} = 7.2$ [V], $B = 1$ [T]

FType0, T2K, $E_d = 208$ [V/cm], $V_{gate} = 9.6$ [V], $B = 1$ [T]

FType0, T2K, $E_d = 208$ [V/cm], $V_{gate} = 12.0$ [V], $B = 1$ [T]



suspicious energy spectra??
=> comparison with simulation!

Status of comparison with simulation

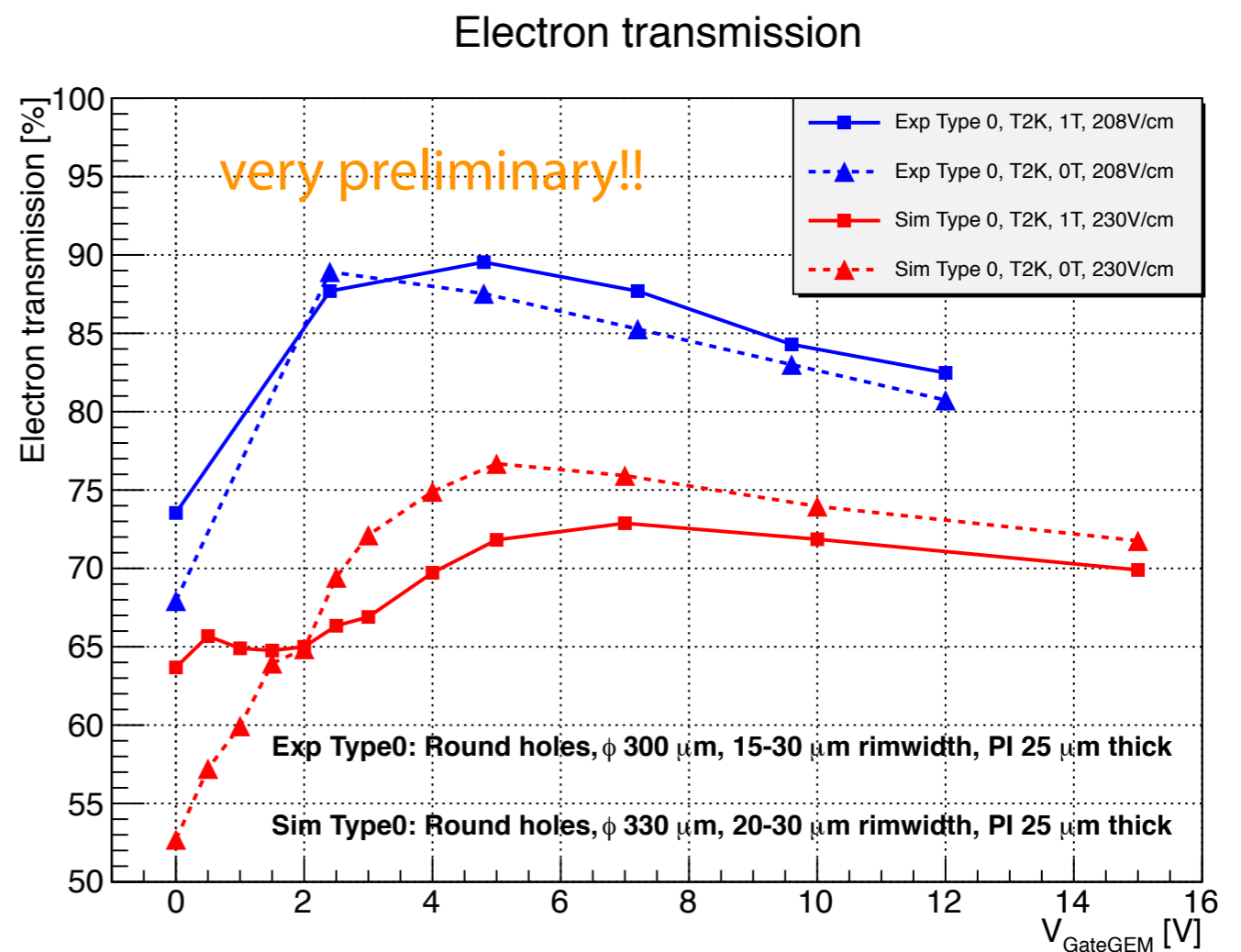
- **Data analysis for Fujikura Gate-GEM Type 0 sample**

- Suspicious energy spectra obtained (= too high electron transmission for 208 V/cm?)
- Require careful comparison of experiment with simulation (ANSYS/Garfield++ based)

- **Simulation framework**

- Nice self-learning materials: "RD51 Simulation School (Jan. 19-21, 2011)"
 - ▶ useful example codes to simulate the CERN standard GEM by using ANSYS and Garfield++
 - ▶ <http://indico.cern.ch/event/110634/>

- Legacy codes from Philippe: started to hold frank exchanges from 2 May (just after I showed my preliminary results for data obtained in April)
- **Reproduced Type 0 simulation** (coll. & extr. eff.) for 0, 1 and 3.5 T (T2K gas)
- Integrate them and rewrite all by myself from scratch to avoid programs from unknown sources
- Understand **how to implement hexagonal holes** (for Type 2)

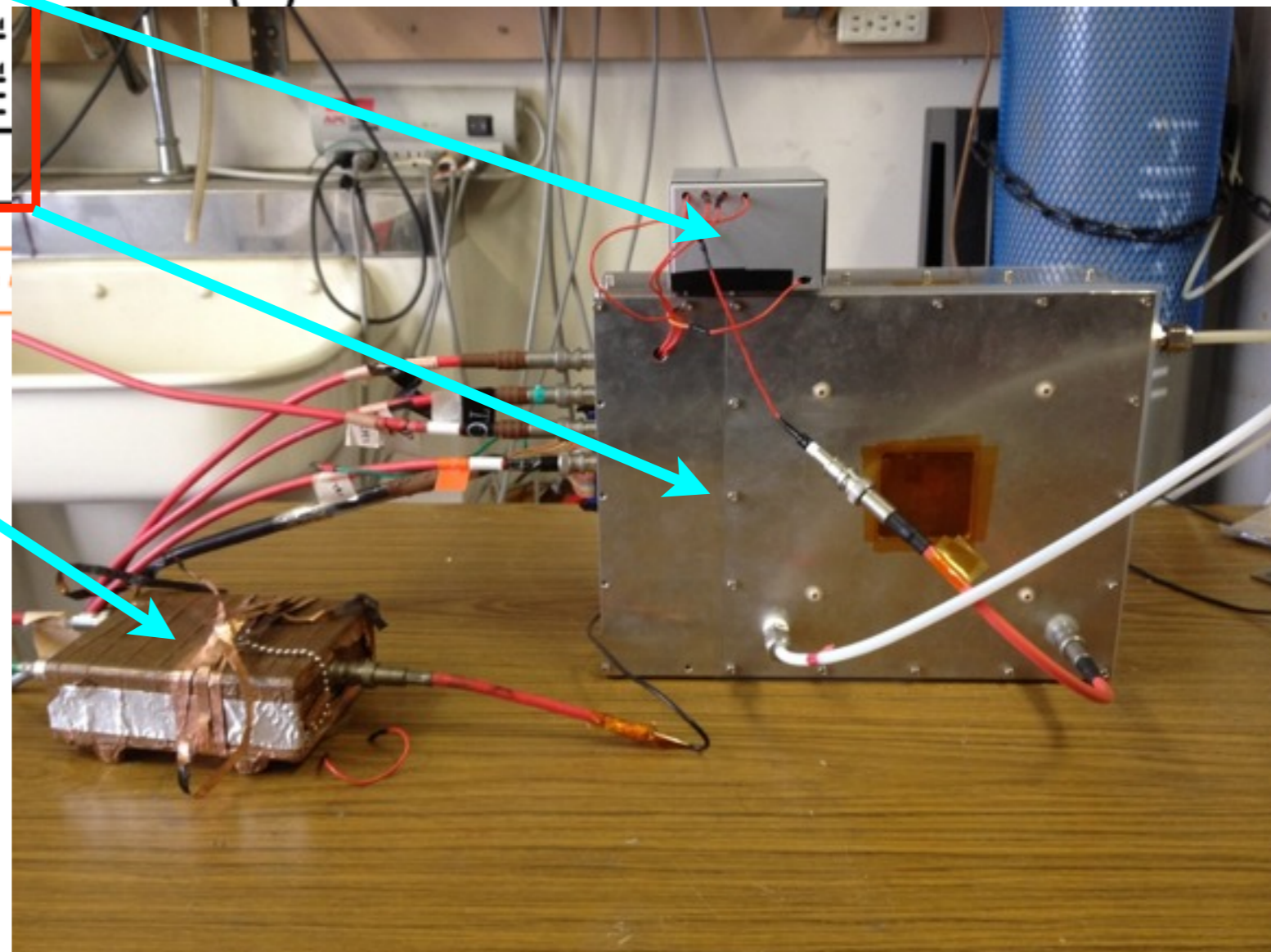
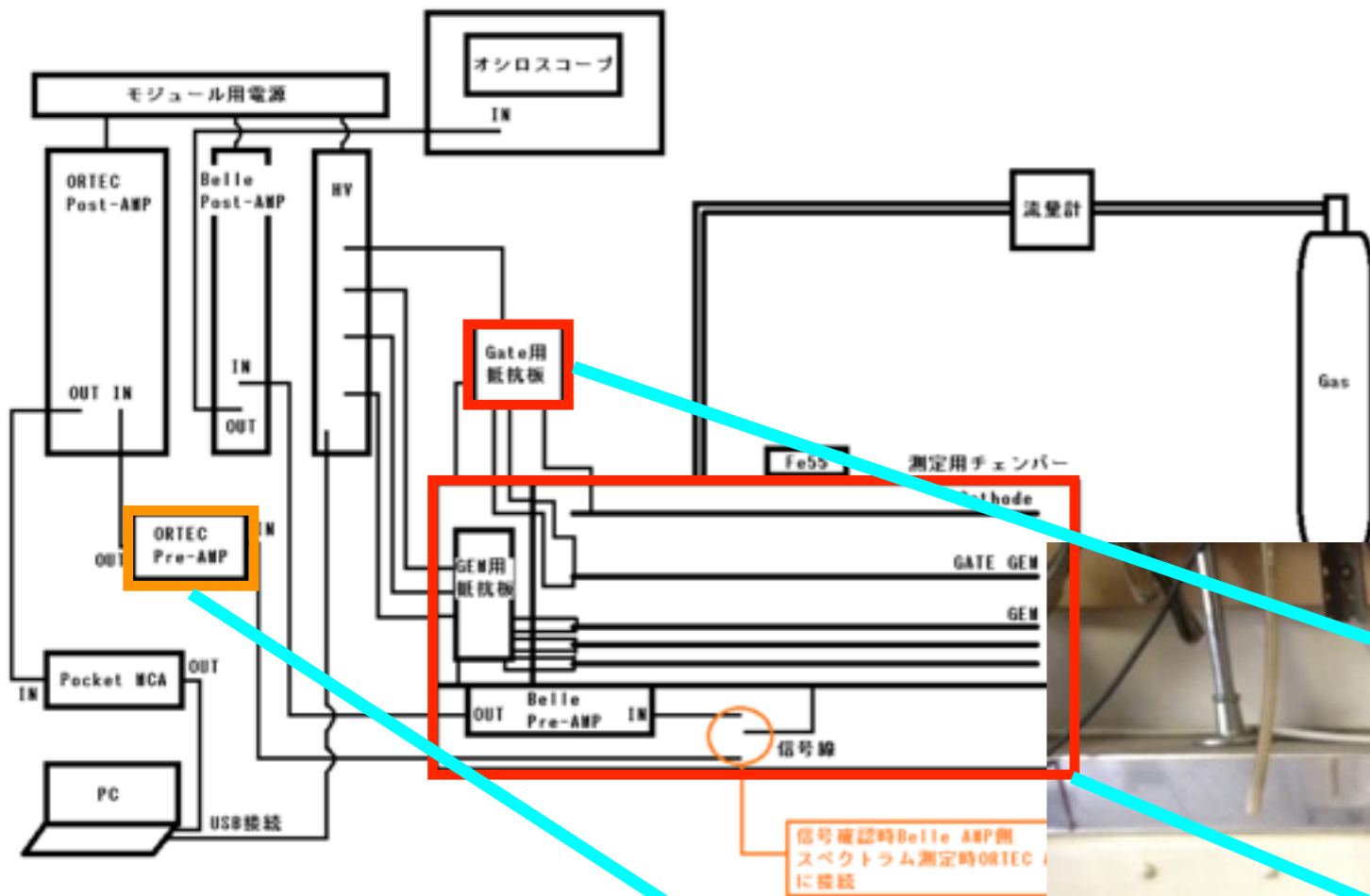


Summary and prospects

- ILD-TPC is planned to be equipped with a gating device located between the drift volume and the gas amplification device to prevent positive ions
- The accumulated positive ions could cause serious distortion of the uniform drift field, thereby degrading the spatial resolution of the TPC
- The gate is required to block the positive ions when it is closed and to have high transparency to drift electrons when it is open
- High optical transparency of the gate is required to ensure its high transmission rate of electrons in the open state because the ILD-TPC is operated in 3.5 T, and in a gas with a high mean free time of drift electrons
- A Gate having a GEM-like structure would be most adapted for a module structure of ILC-TPC since it is easier to implement and allows a low switching voltage of a few tens of volts
- To achieve high electron transmission, 2 types of large-aperture GEMs which have ~75% optical transparency were produced by Fujikura
- These samples have been tested with a test chamber installed in the KEK MRI type 1 T solenoid, and the performance of high transmission has been observed (for Fujikura Gate-GEM Type 2)
- Evaluation of the measurement results by using the ANSYS-Garfield based simulation framework is ongoing
- Additional Fujikura Gate-GEM samples and RAYTECH samples will be tested from 7 July at KEK cryo center

Backup

GEM 測定用チェンバー



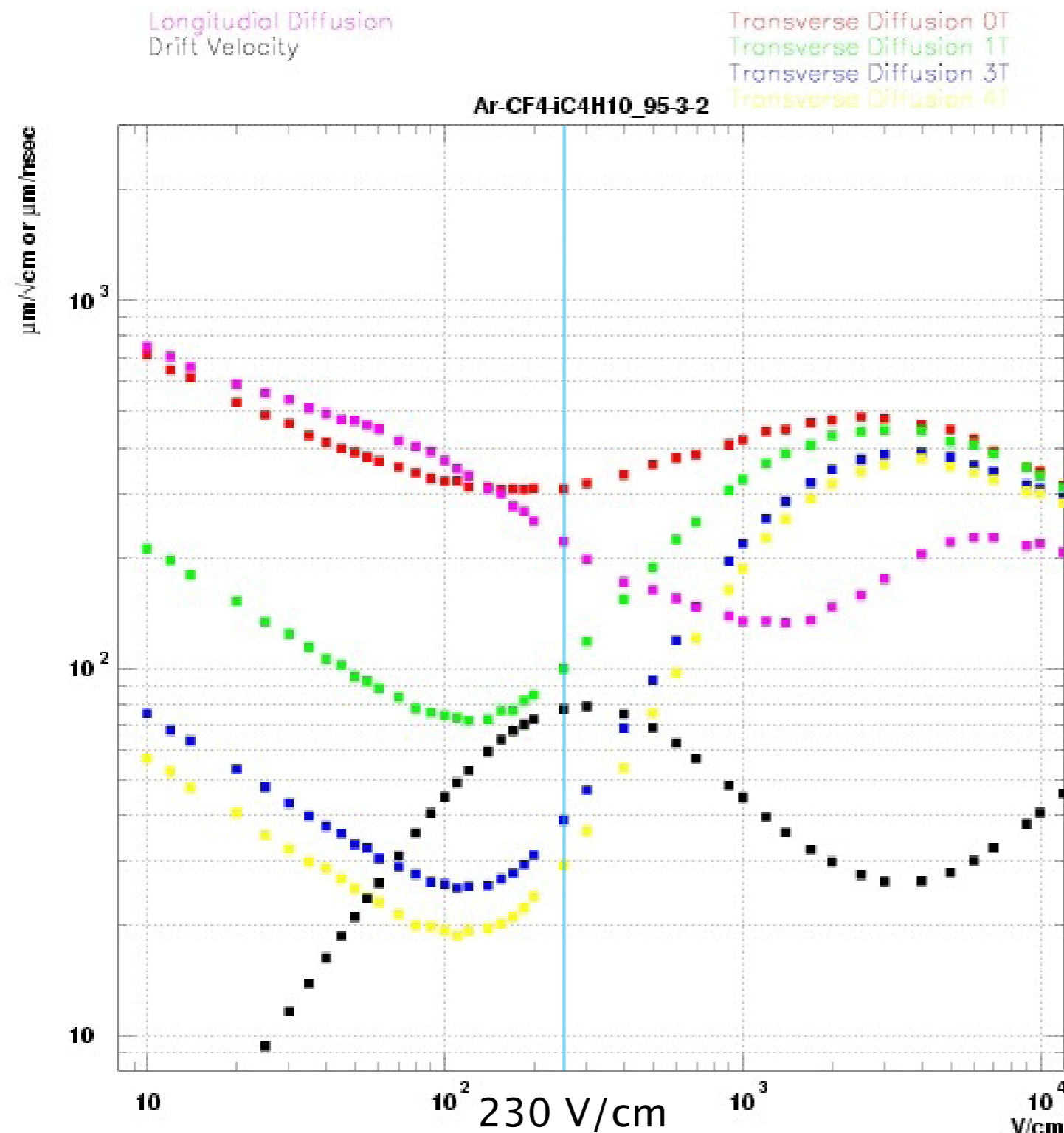
アルミニウムプレート上に
写真のように立てた状態
で据え付け

Performance and design parameters

- Performance and design parameters for the ILD-TPC with standard electronics and pad readout

Parameter			
Geometrical parameters	r_{in}	r_{out}	z
	329 mm	1808 mm	± 2350 mm
Solid angle coverage	Up to $\cos \theta \simeq 0.98$ (10 pad rows)		
TPC material budget	$\simeq 0.05 X_0$ including outer fieldcage in r $< 0.25 X_0$ for readout endcaps in z		
Number of pads/timebuckets	$\simeq 1-2 \times 10^6/1000$ per endcap		
Pad pitch/ no.padrows	$\simeq 1 \times 6$ mm ² for 220 padrows		
σ_{point} in $r\phi$	$\simeq 60$ μm for zero drift, < 100 μm overall		
σ_{point} in rz	$\simeq 0.4 - 1.4$ mm (for zero – full drift)		
2-hit resolution in $r\phi$	$\simeq 2$ mm		
2-hit resolution in rz	$\simeq 6$ mm		
dE/dx resolution	$\simeq 5$ %		
Momentum resolution at B=3.5 T	$\delta(1/p_t) \simeq 10^{-4}/\text{GeV}/c$ (TPC only)		

Drift velocity and diffusion (T2K gas)



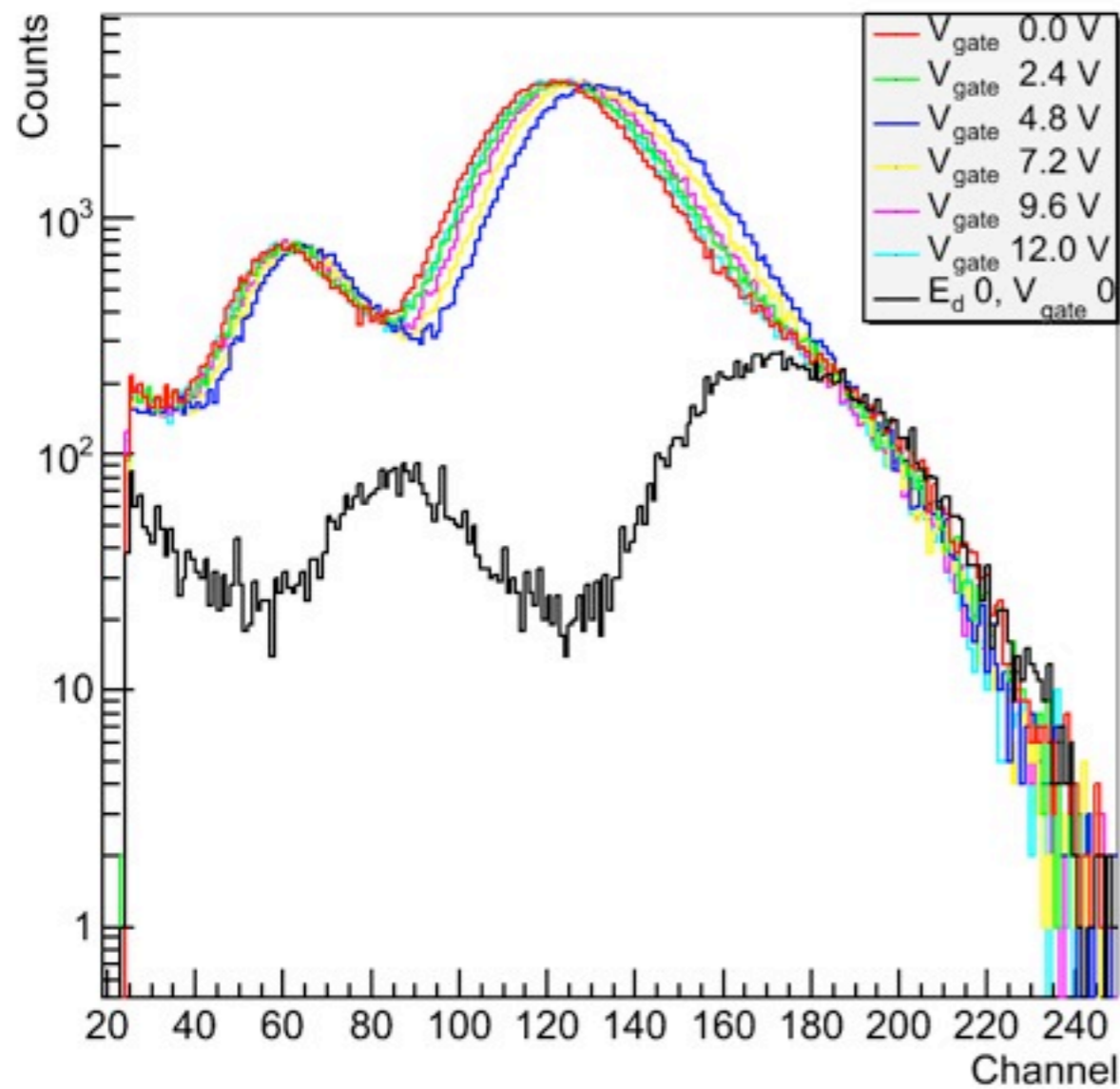
If we require the azimuthal resolution of 100 μm at $z = 200$ cm the diffusion constant (D), which is essentially the only free (controllable) parameter depending on the choice of gas mixture, needs to be smaller than $30 \mu\text{m}/\sqrt{\text{cm}}$.

The diffusion constant of drift electrons under the influence of an axial magnetic field (B) is given by $D(B) = D(B = 0)/\sqrt{1 + (\omega\tau)^2}$, where $\omega \equiv e \cdot B/m$, the electron cyclotron frequency, and τ is the mean free time of drift electrons between collisions with gas molecules. Therefore we need a gas mixture in which $D(B = 0)$ is small (cool) and τ is fairly large (fast) under a moderate drift field (E)!

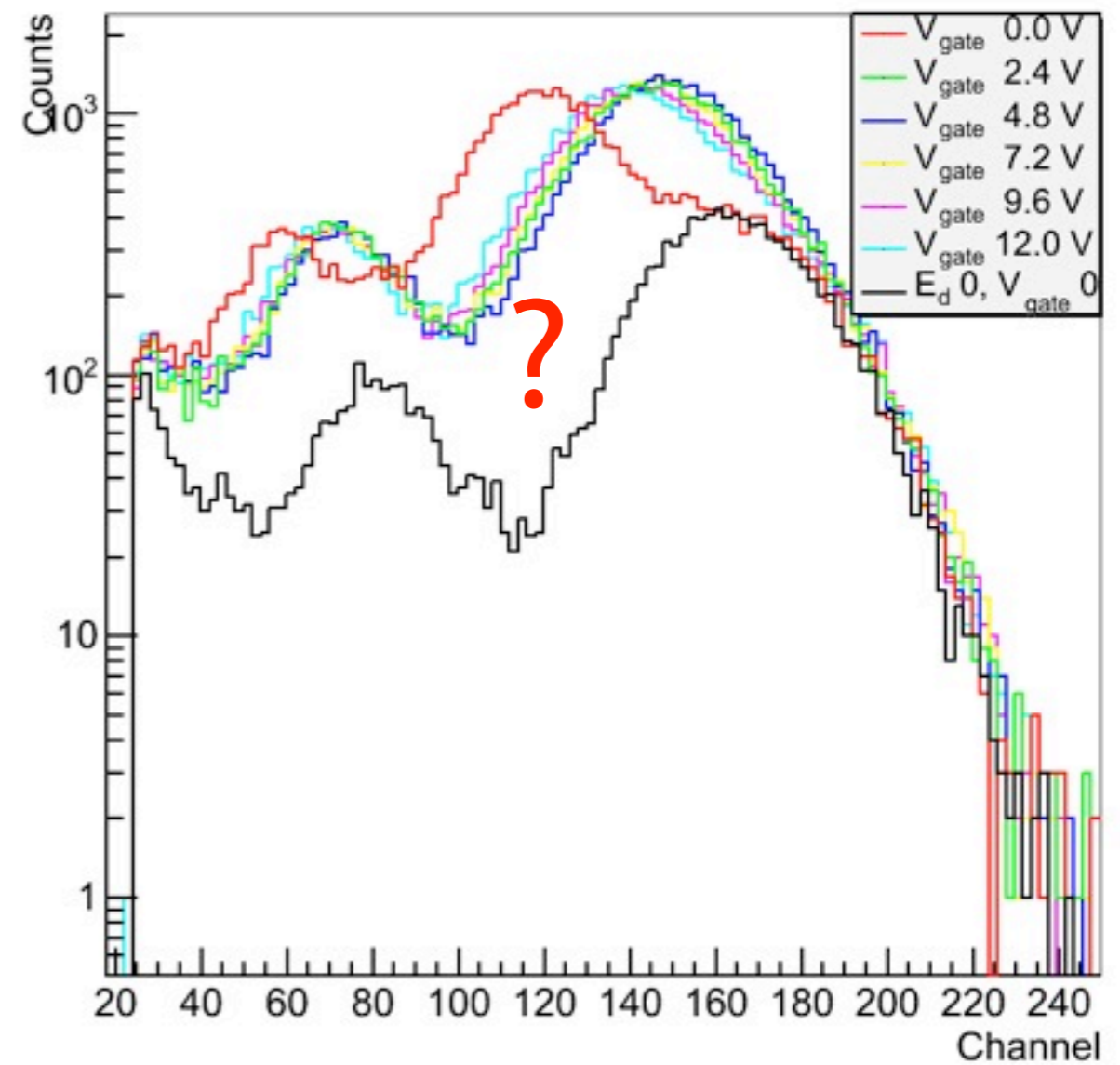
- ▶ The diffusion constant D is related to the diffusion coefficient (D^*) through $D^2 = 2D^*/W$, where W is the electron drift velocity.
- ▶ The electron drift velocity is given by $W = e \cdot E/m \cdot \tau$ with e (m) being the electron charge (mass). A large value of τ , therefore, means a fast gas.

Raw energy spectrum

Energy spectrum (Type 2, $E_d = 208$ V/cm)

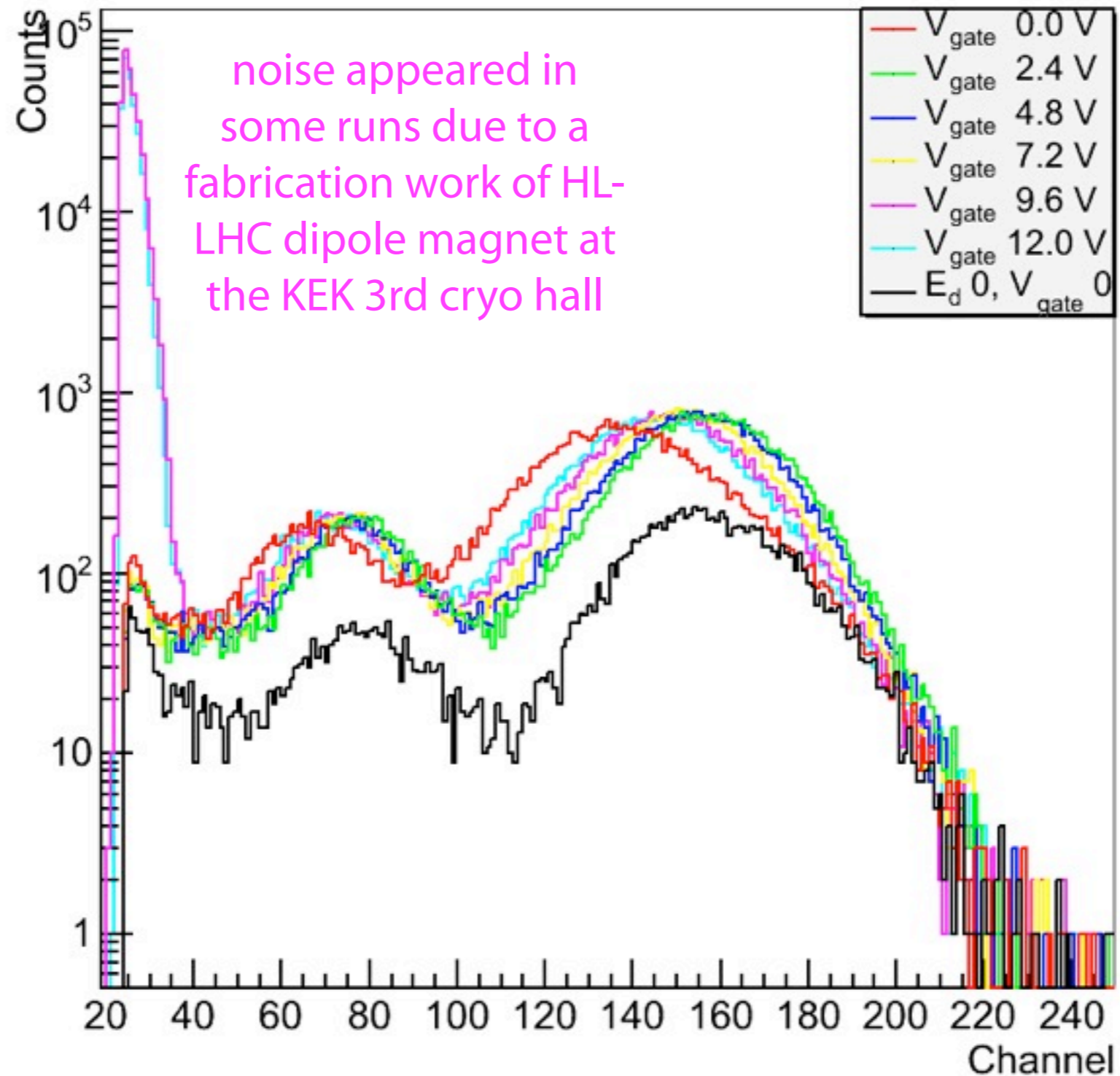


Energy spectrum (Type 0, $E_d = 208$ V/cm)



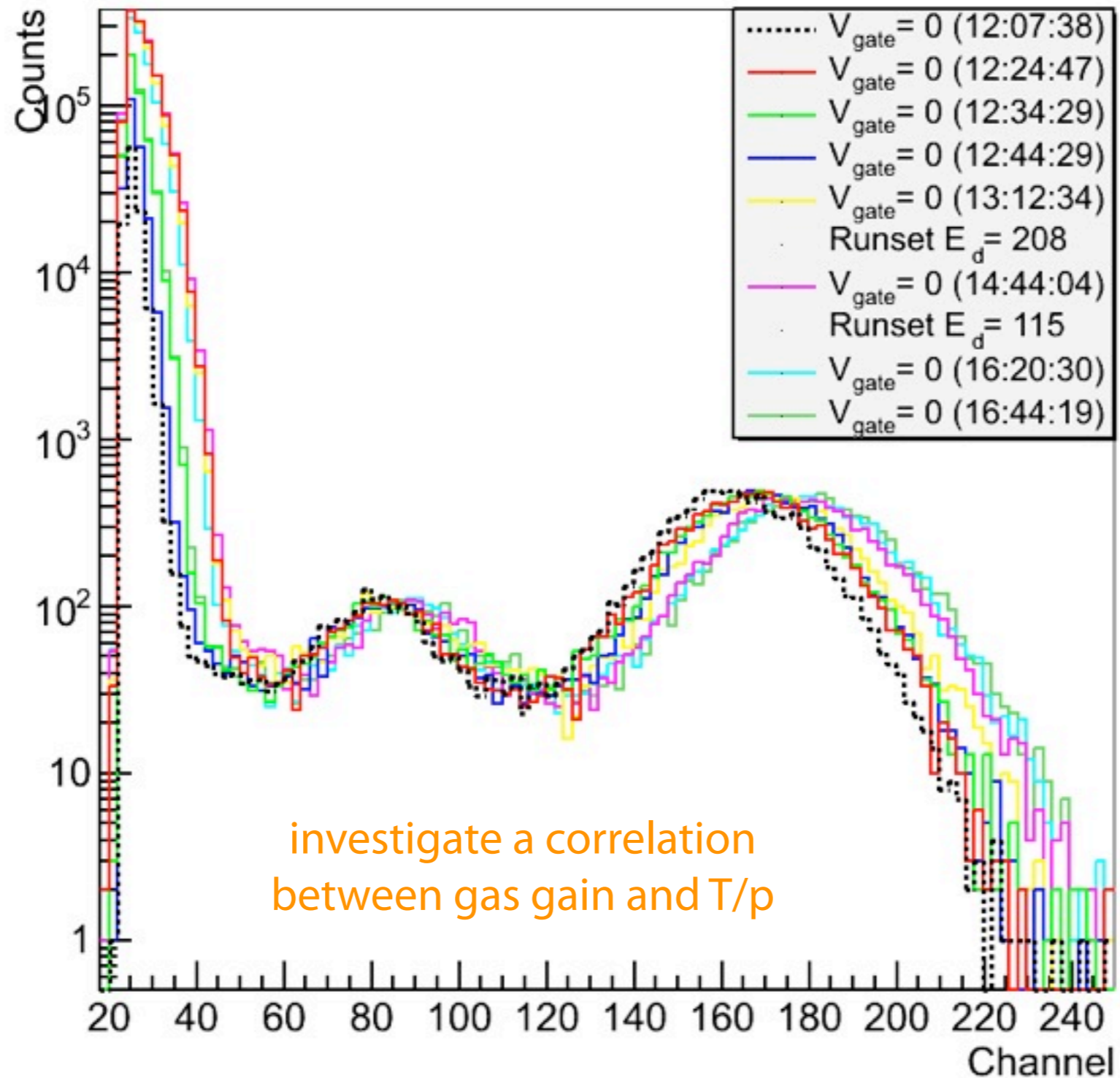
Raw energy spectrum w/ noise

Energy spectrum (Type 0, $E_d = 115$ V/cm)



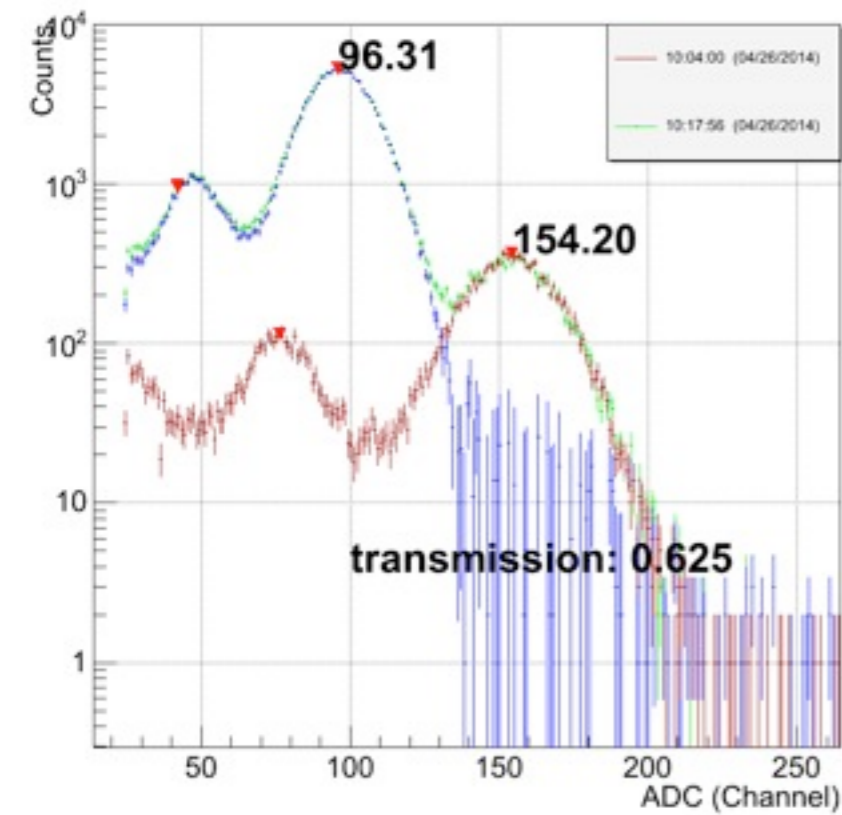
Gain stability ($E_{\text{drift}} = 0$ runs in a day)

Gain fluctuation (Type 0, $E_d = 0$ V/cm, 25 Apr. 2014)

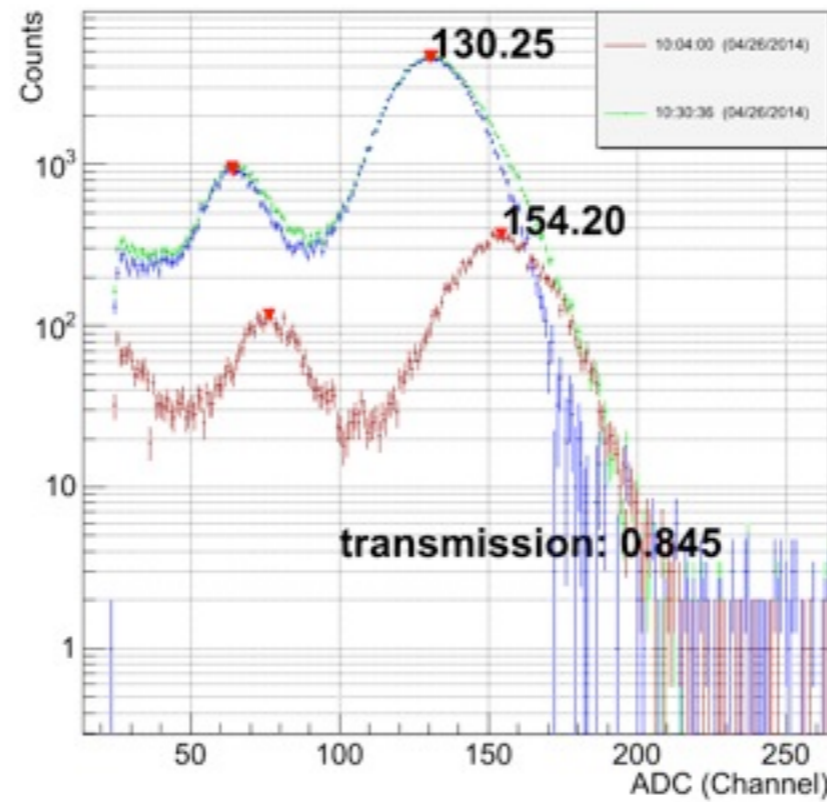


Type 2, T2K gas, $B = 0$, $E_d = 208$ V/cm

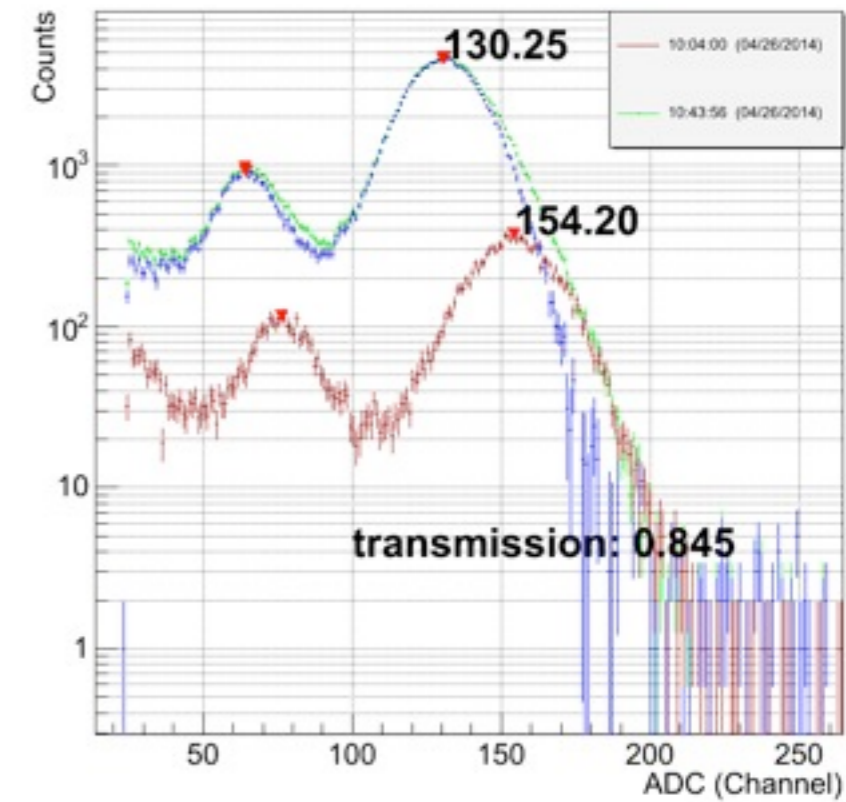
FType2, T2K, $E_d = 208$ [V/cm], $V_{gate} = 0.0$ [V], $B = 0$ [T]



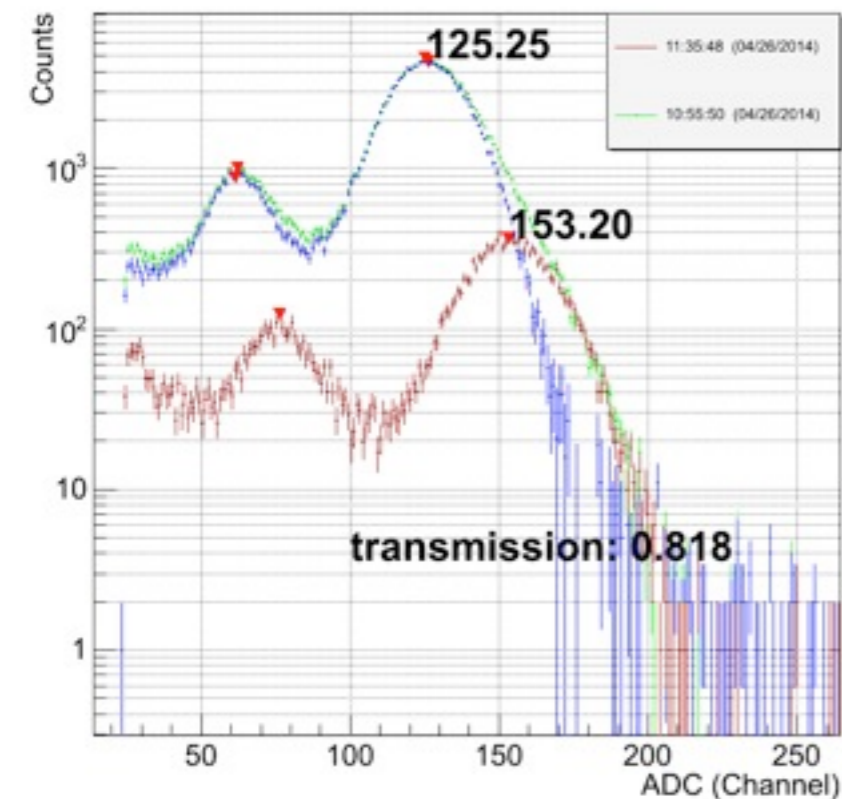
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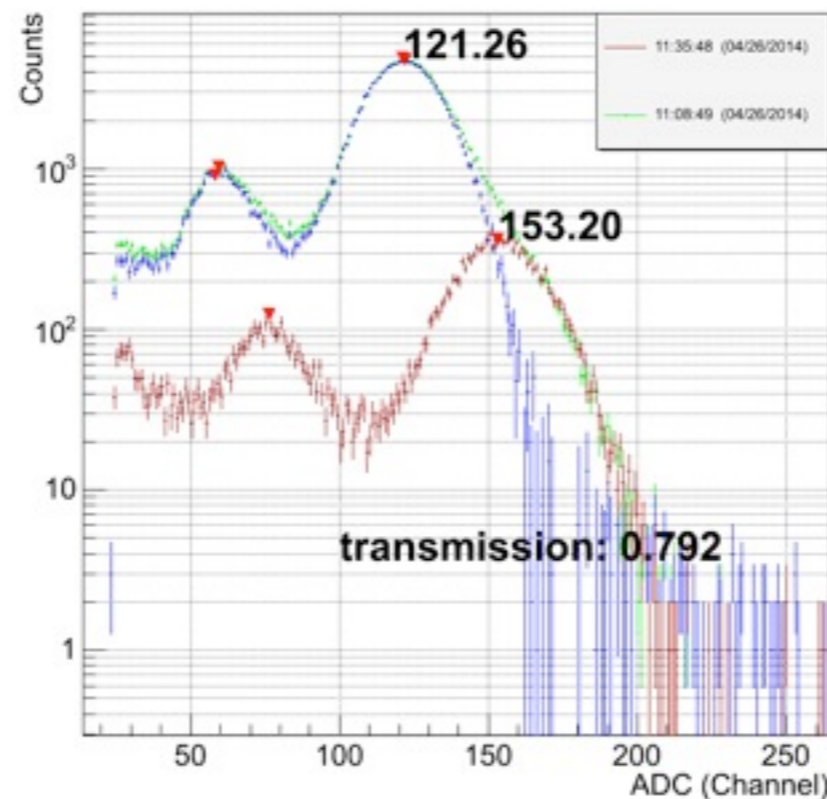
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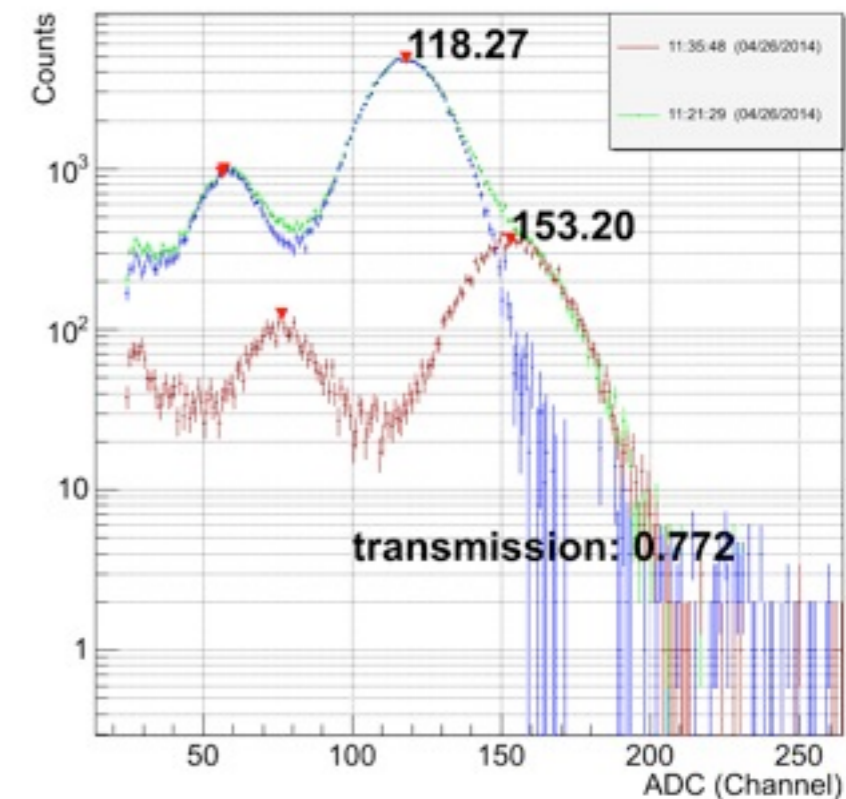
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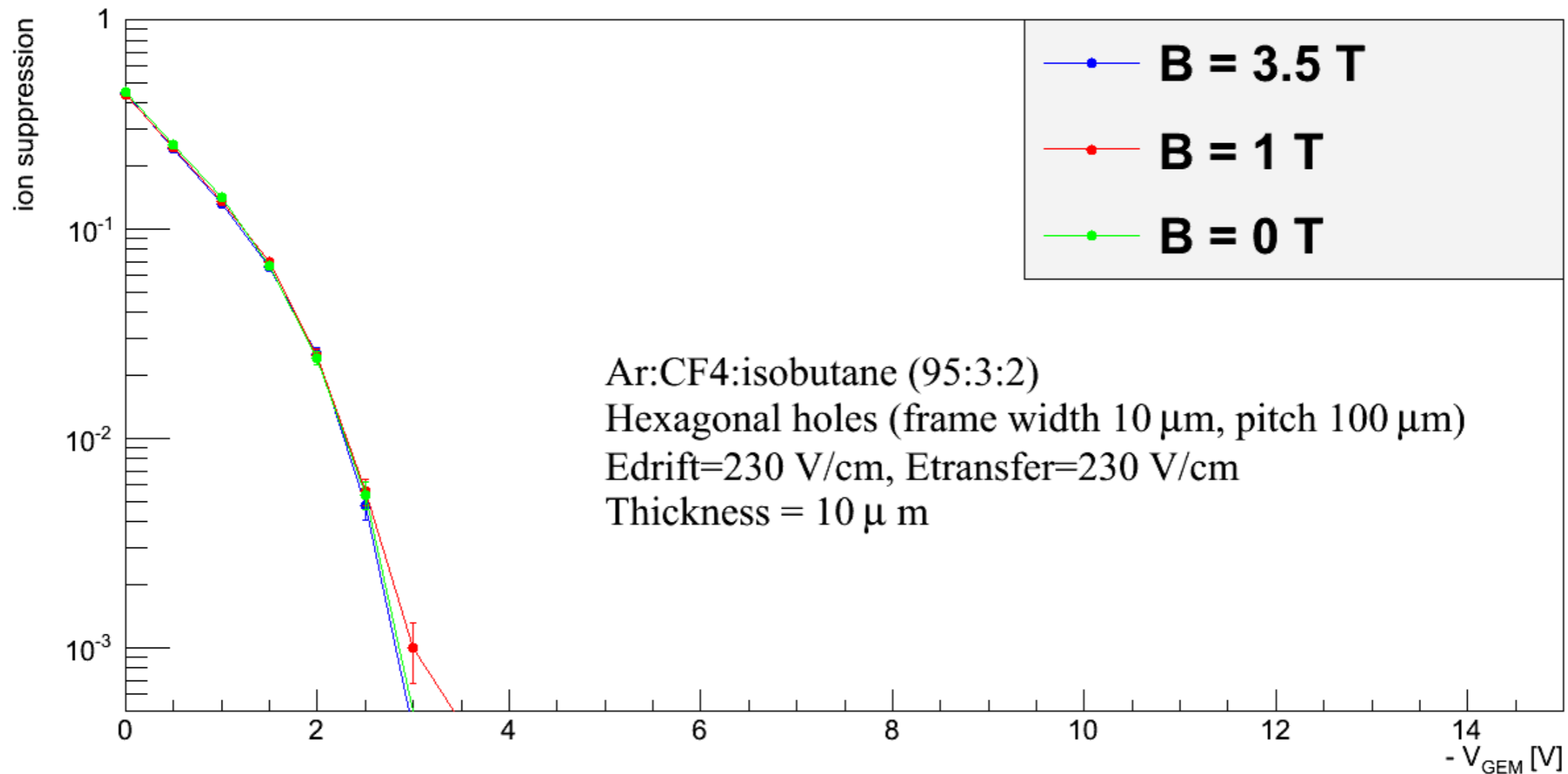
FType2, T2K, $E_d = 208$ [V/cm], $V_{gate} = 9.6$ [V], $B = 0$ [T]



FType2, T2K, $E_d = 208$ [V/cm], $V_{gate} = 12.0$ [V], $B = 0$ [T]



Closing the gate



As expected, the magnetic field has little influence on the ions
A GEM voltage above **3V** already gives enough ion suppression.